



An Organic-Photoconductive-Film CMOS Image Sensor's Advanced Technologies

Kazuko Nishimura

Panasonic Corporation, Osaka, Japan

Who am I ?



Kazuko Nishimura



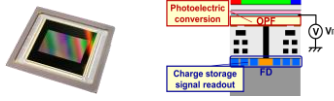


Mechanical Engineering

- Robot Manipulator using GA



R&D / Semiconductor Division

- High-Speed ADC for DVD, DVC 
- Optical Transceiver for FTTH 
- Full Segment Tuner for Mobile Phone 
- CMOS Image Sensor for several products 
- **OPF CMOS Image Sensor** 

Manager of Image Sensor Project, Technology Division

Society committee activities

1. A-SSCC DC subcommittee chair
 2. ISSCC IMMD subcommittee
 3. IEEE SSCS DL
 4. IEEE SSCS Adcom
 5. Image Sensor Europe advisory
 6. CREST technical advisor
 7. NISTEP expert technical researcher
- *6,7 Japanese Government Ministry of Education Project

OPF: Organic Photoconductive Film

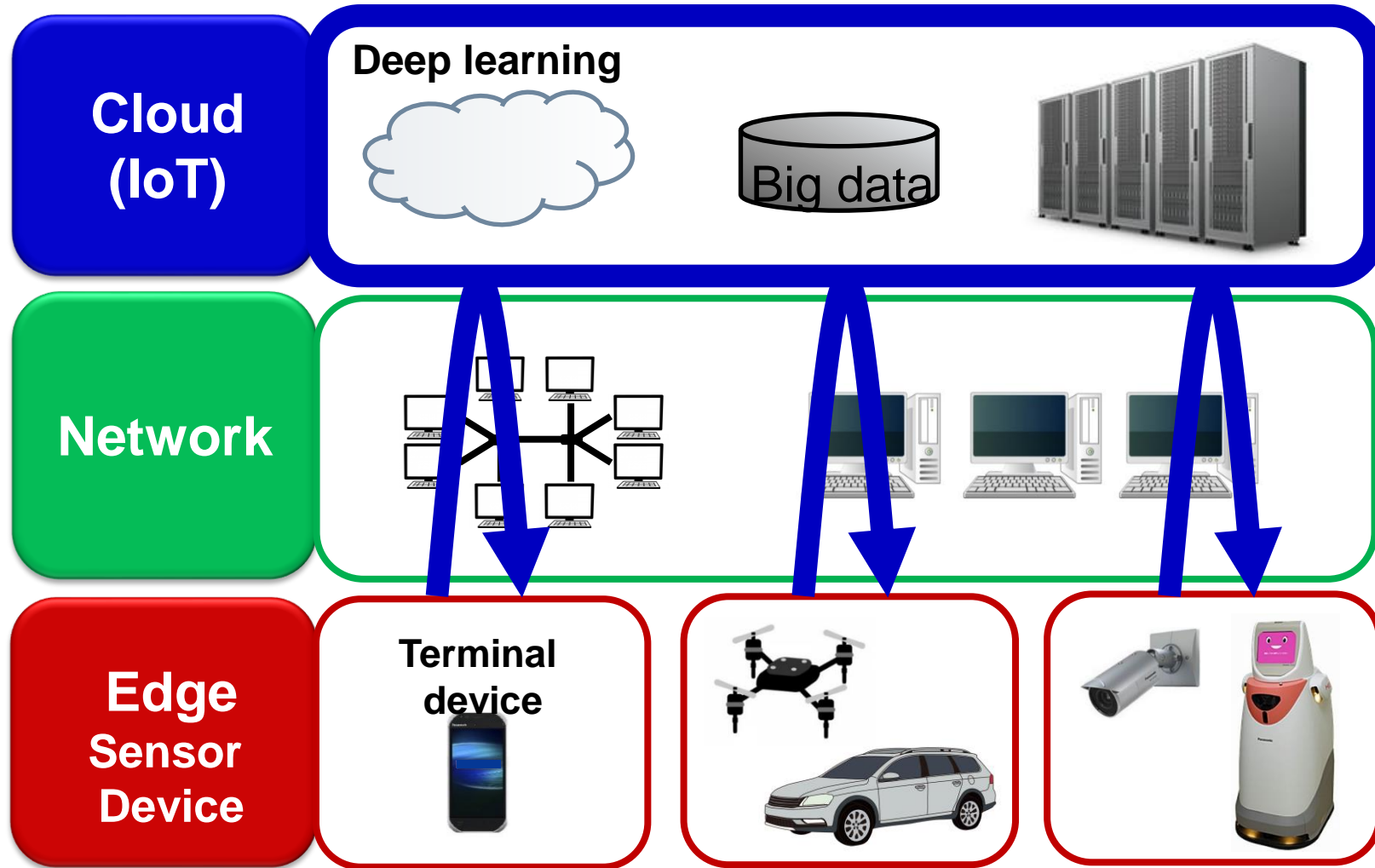
Outline

- **Background**
 - **What is OPF image sensor**
 - **Advanced technologies of OPF image sensor**
 - 1) **Wide dynamic range**
 - 2) **Photoelectric conversion controlled global shutter**
 - 3) **NIR sensitivity modulation RGB-NIR sensor**
 - **8K4K sensor technologies**
 - **Conclusion**
-

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Now : Cloud ➡ Edge



Amount of data:

large

Response:

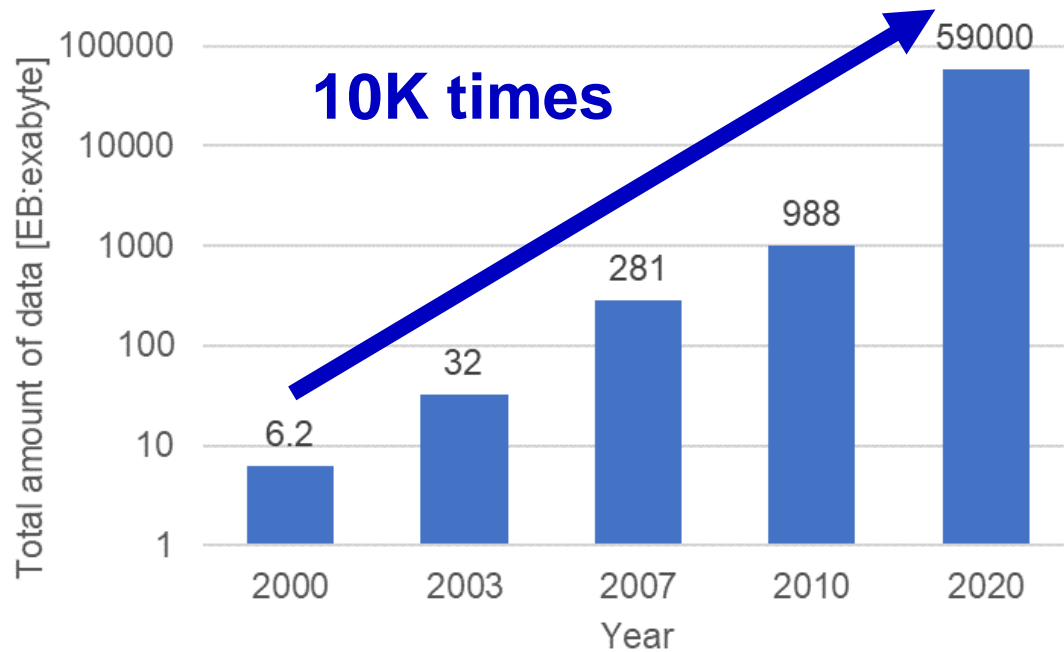
slow

Security:

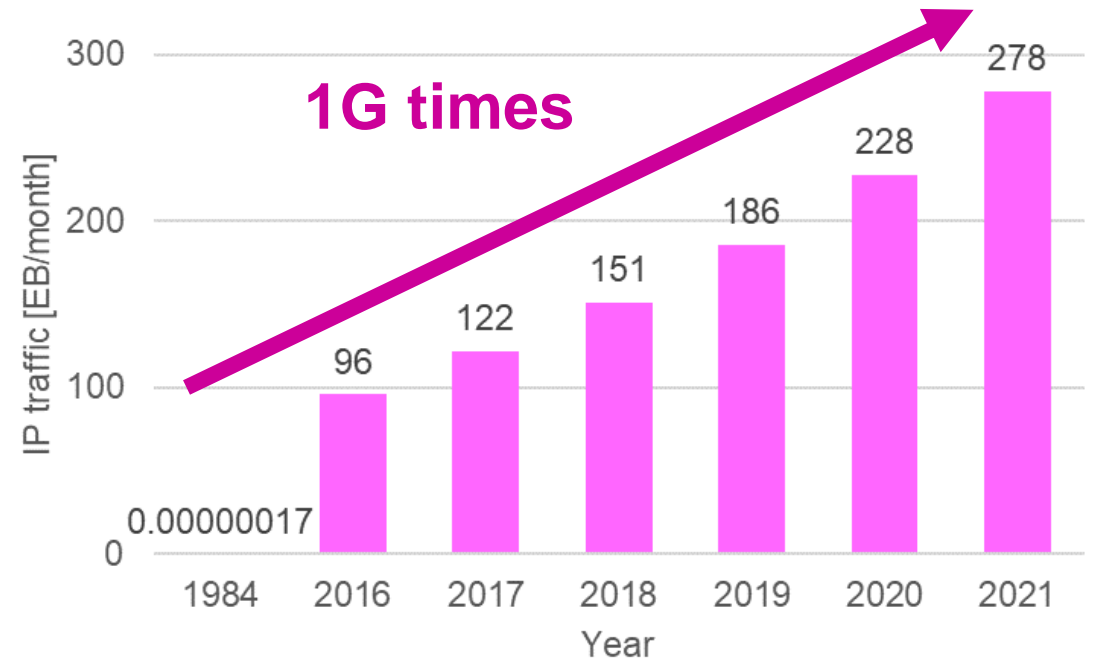
problem

Big Data Problem

Total Amount of DATA

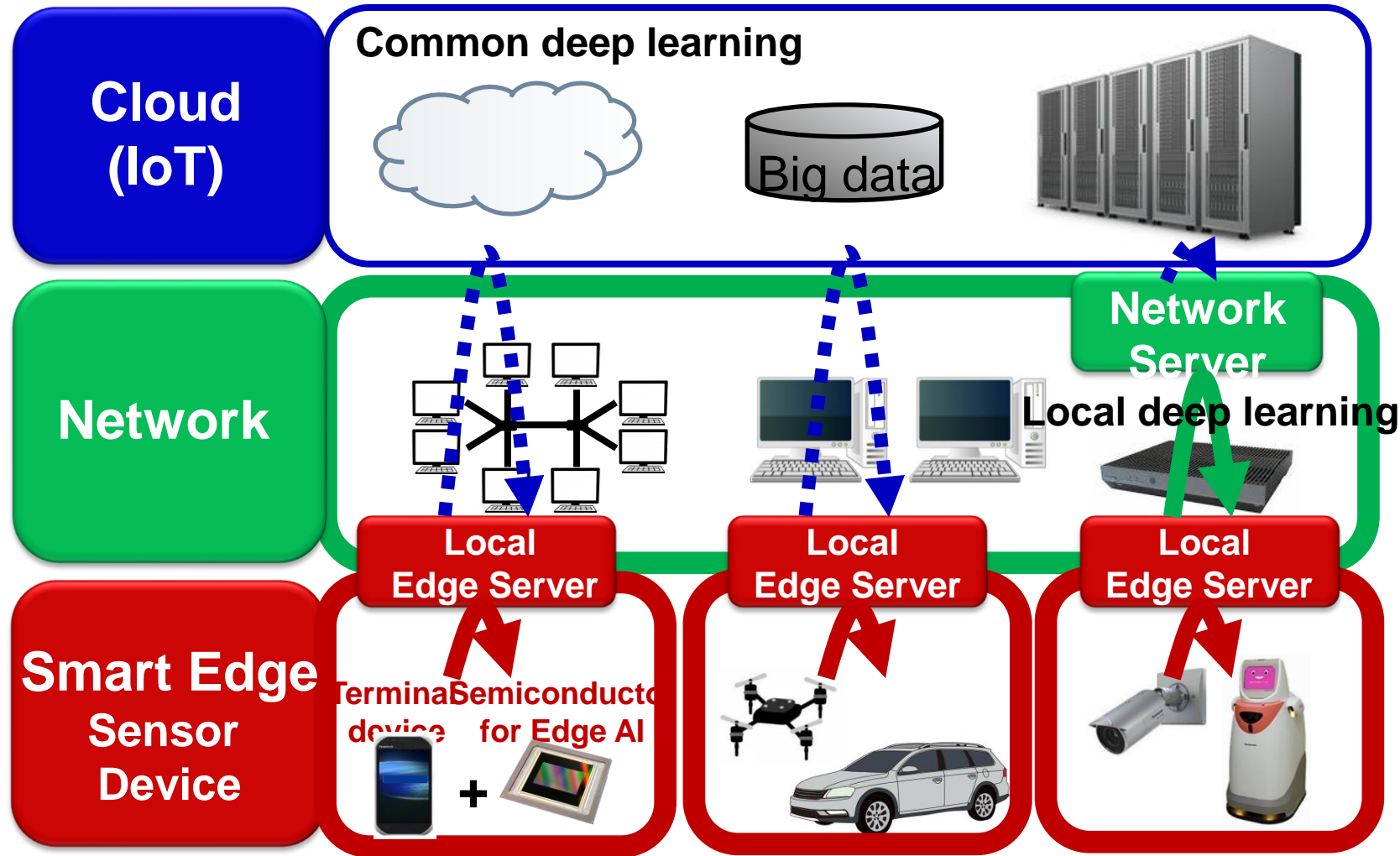


IP Traffic (/month)



By 2030, over 50% of the data will be **real-time data**.

Near Future : Smart Edge



Only sharing

- Common AI data
- Others' experience

Amount of data: **small**

Response: **fast**

Security: **safe**

Image Sensors become **“Key Devices of Smart Edge”**



- **Needs for “Imaging” and “Sensing”**
- **Wide dynamic range (High saturation/Low noise)**
 - **High speed imaging**
 - **High sensitivity** ...

“Imaging” and “Sensing” **Beyond Human Ability**

Capture accurately → **Look at something invisible** → **Predict the next action**

We have to develop technologies for achieving these requests.

Under backlight

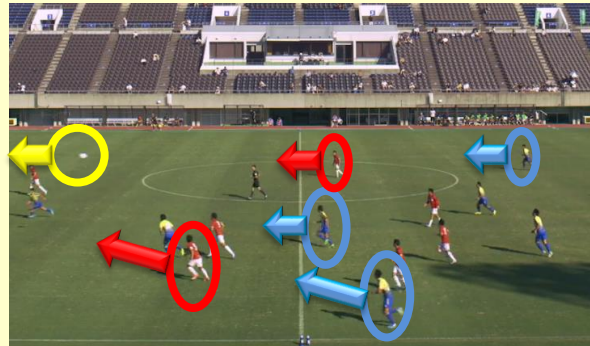
People detection
at disaster site



Required technology:
Wide dynamic range

At high speed

Motion detection
in the sport scene



Required technology:
Global shutter
(Multiple-angles, Multiple-exposure)

In the dark

Non-destructive inspection



Required technology:
RGB + other wavelength

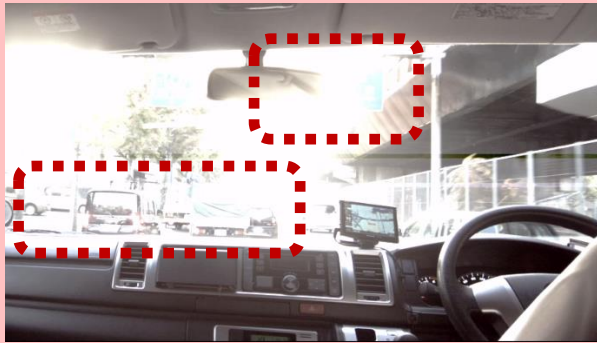
“Imaging” and “Sensing” **Beyond Human Ability**

Capture accurately ➔ **Look at something invisible** ➔ **Predict the next action**

We have to develop technologies for achieving these requests.

Under backlight

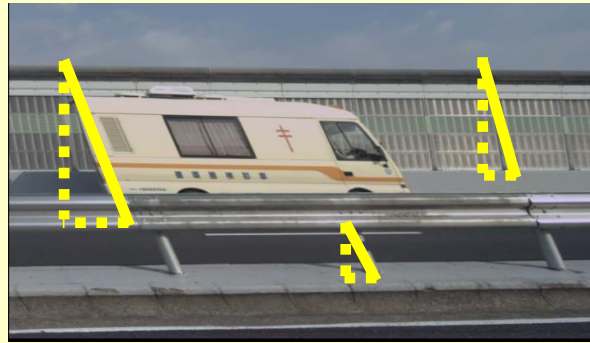
Accurate peripheral recognition
in dark & bright conditions



Required technology:
Wide dynamic range

At high speed

Accurate peripheral recognition
in all condition



Required technology:
Global shutter

In the dark

Accurate peripheral recognition
In day & night



Required technology:
RGB + other wavelength

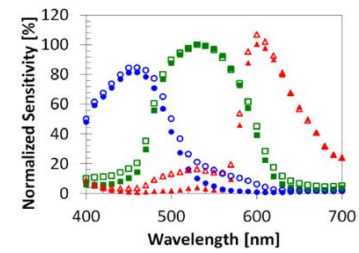
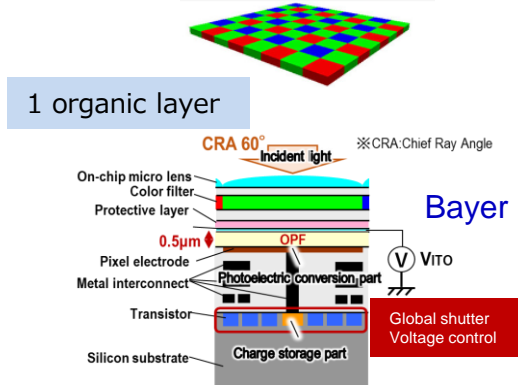
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Comparison of OPF Image Sensor Configurations of Each Company

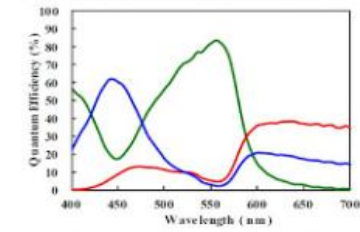
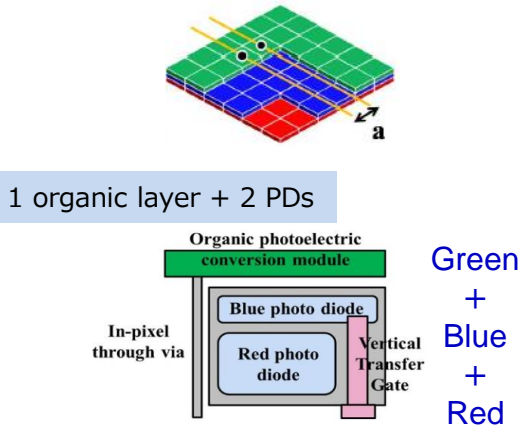
Panasonic

IEDM2015, ISSCC2016,2017,2018,
VLSI2013,2018, IS Europe2019



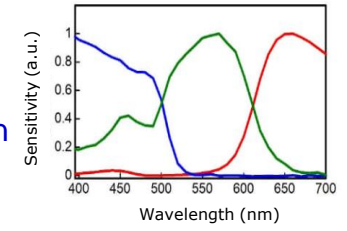
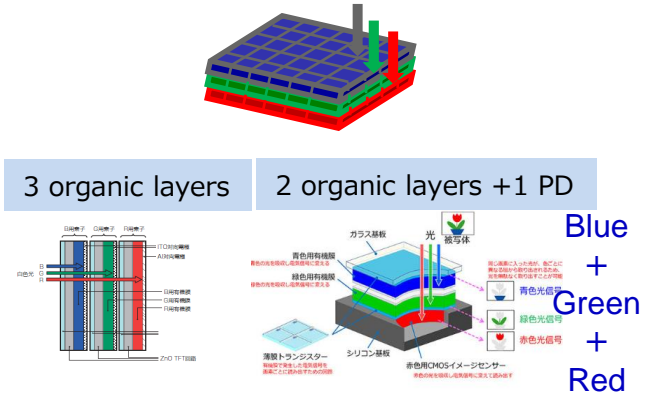
SONY

IEDM2019



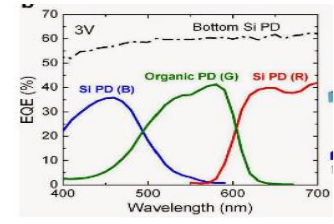
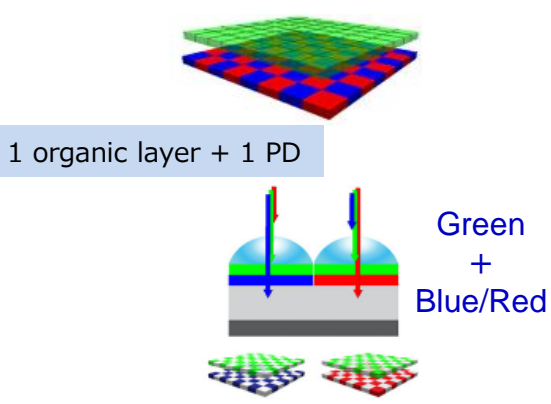
NHK

NHK STRL Report 2010~2020



Samsung

Nature2015, OSA Optics Express 2019

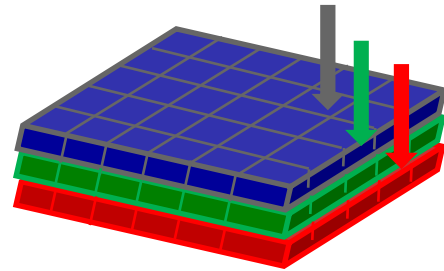


Comparison of OPF Image Sensor Configurations of Each Company

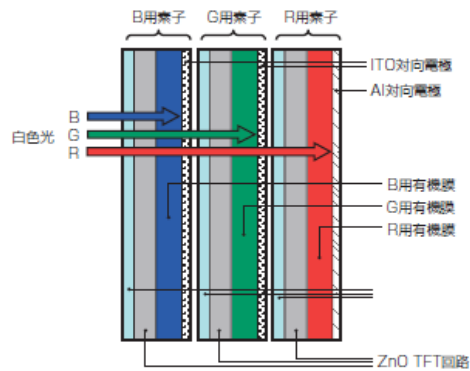
NHK 1

NHK STRL Report 2010~2019

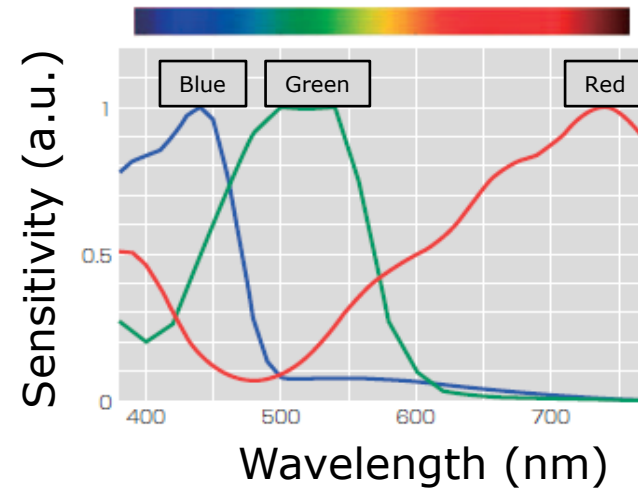
※NHK : Nippon Hoso Kyokai : Japan Broadcasting Corporation
STRL : Science & Technology Research Laboratories



3 organic layers



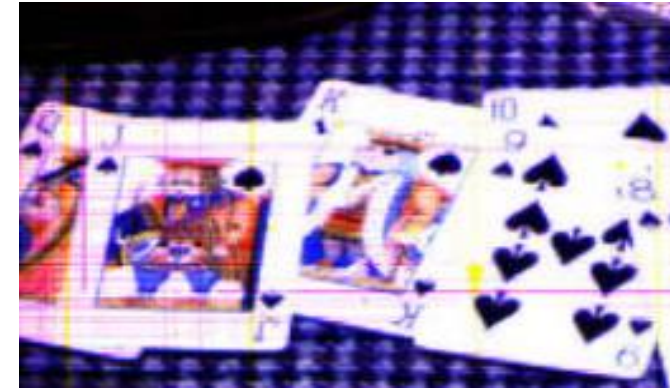
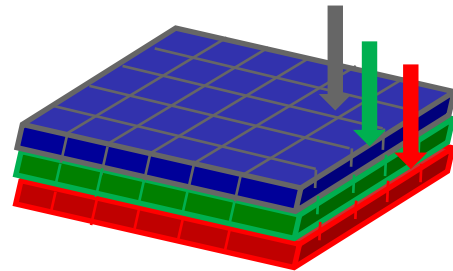
Blue
Green
Red



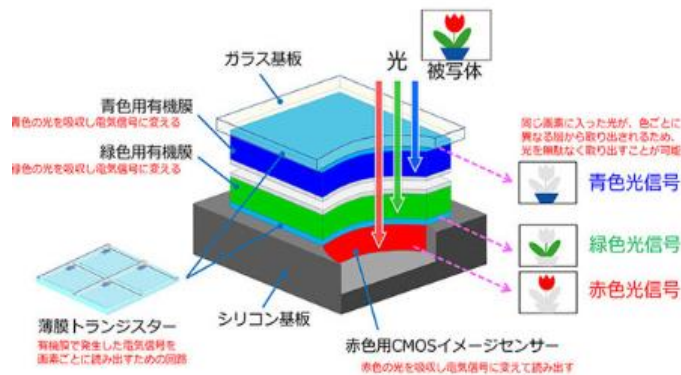
Comparison of OPF Image Sensor Configurations of Each Company

NHK 2

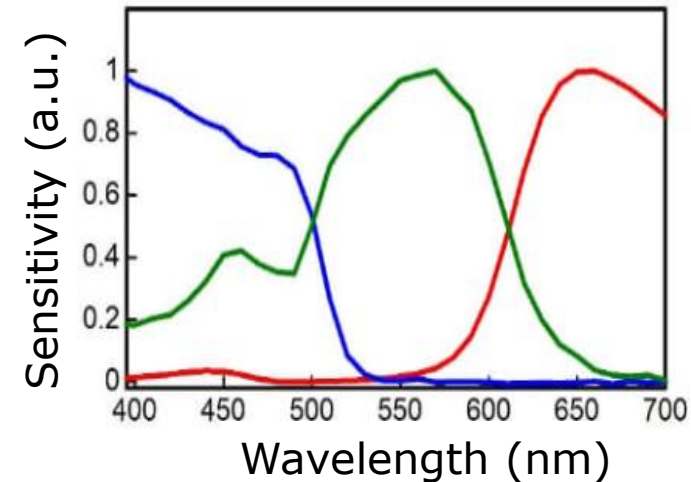
NHK STRL Report 2020



2 organic layers + 1 PD



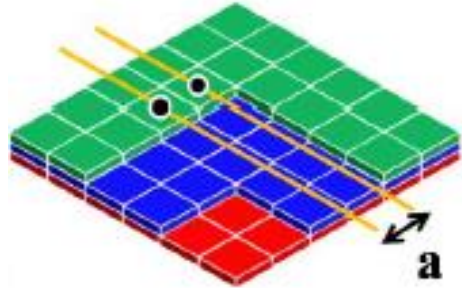
Blue
Green
+
Red



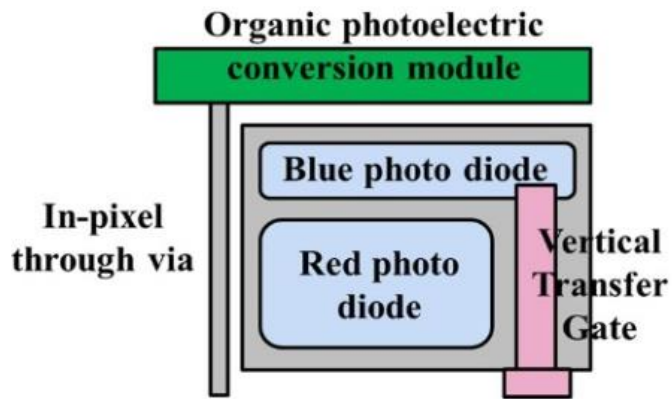
Comparison of OPF Image Sensor Configurations of Each Company

SONY

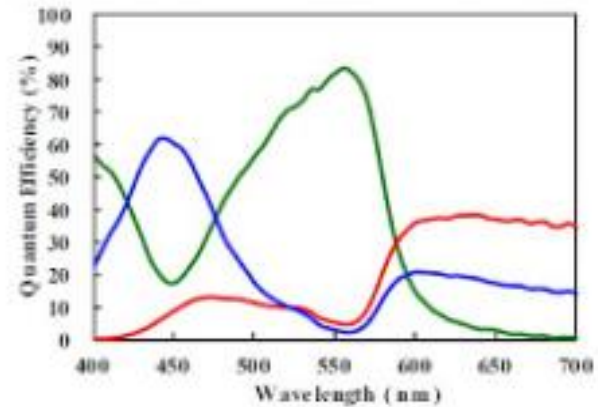
IEDM2019



1 organic layer + 2 PDs



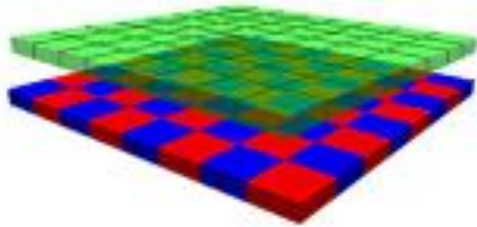
Green
+
Blue
Red



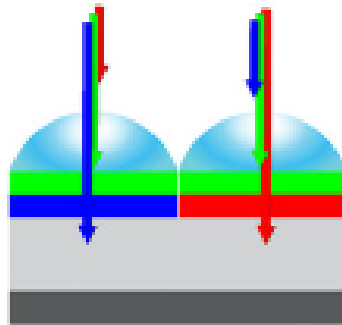
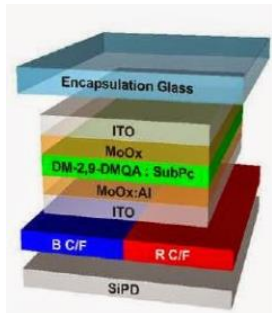
Comparison of OPF Image Sensor Configurations of Each Company

Samsung

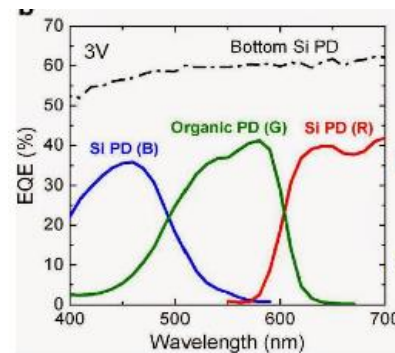
Nature2015, OSA Optics Express 2019



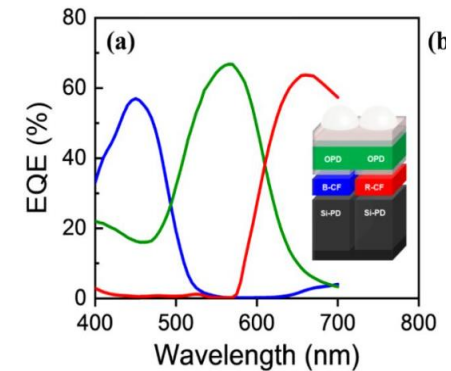
1 organic layer + 1 PD



Green
+
Blue/Red



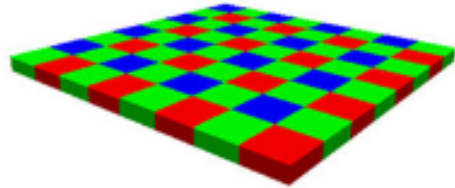
EQE improved in 2019



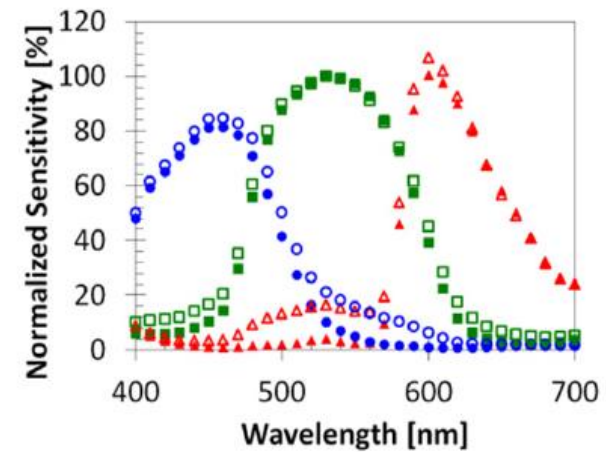
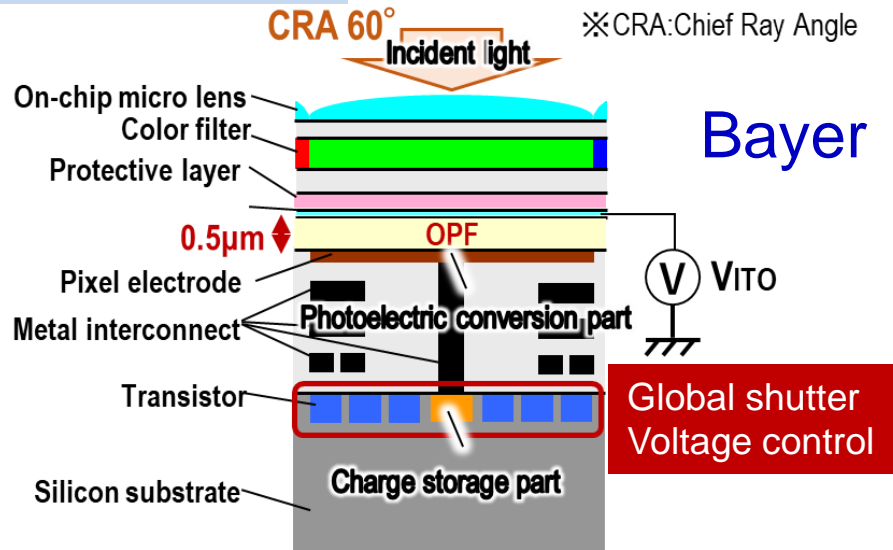
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IEDM2015, ISSCC2016,2017,2018,
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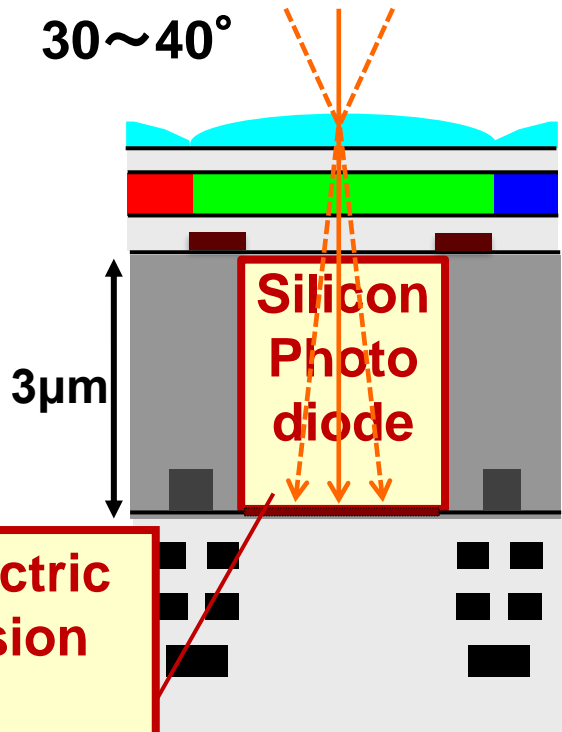


1 organic layer



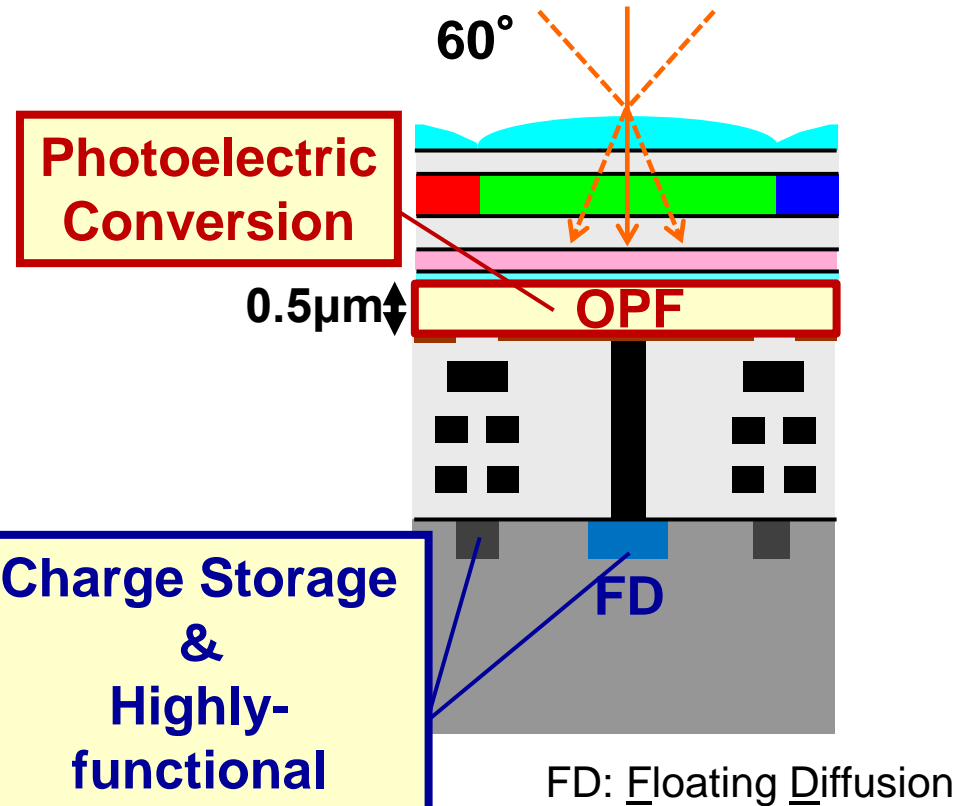
OPF Image Sensor of Panasonic

BSI Si image sensor



Photoelectric Conversion & Charge Storage

OPF image sensor of Panasonic



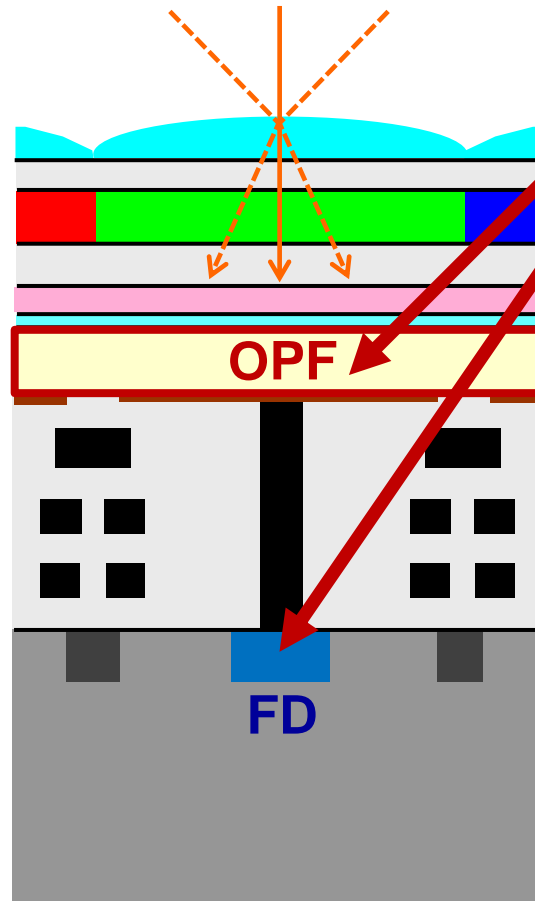
Charge Storage & Highly-functional Circuits

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Advanced Technologies of OPF Image Sensor

OPF image sensor

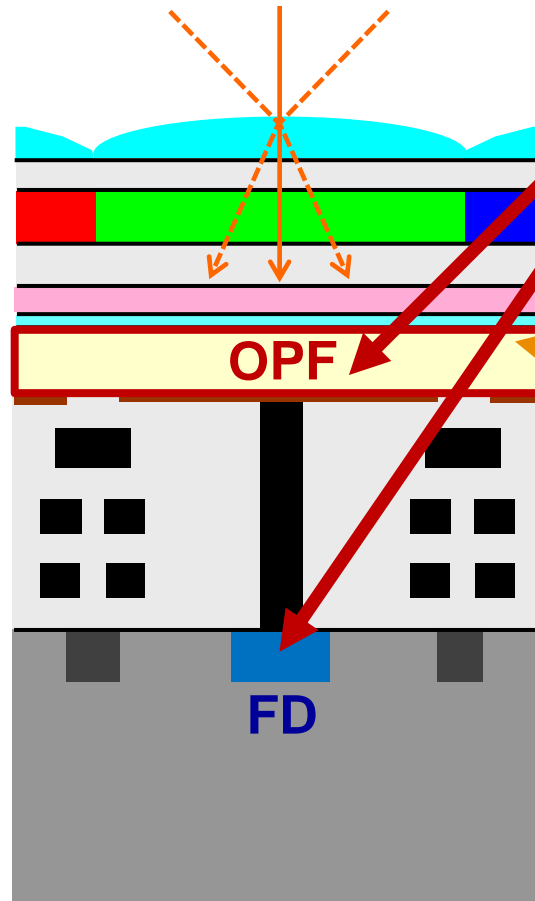


Key Tech. 1: Wide dynamic range

Photoelectric conversion and charge storage parts are completely independent

Advanced Technologies of OPF Image Sensor

OPF image sensor



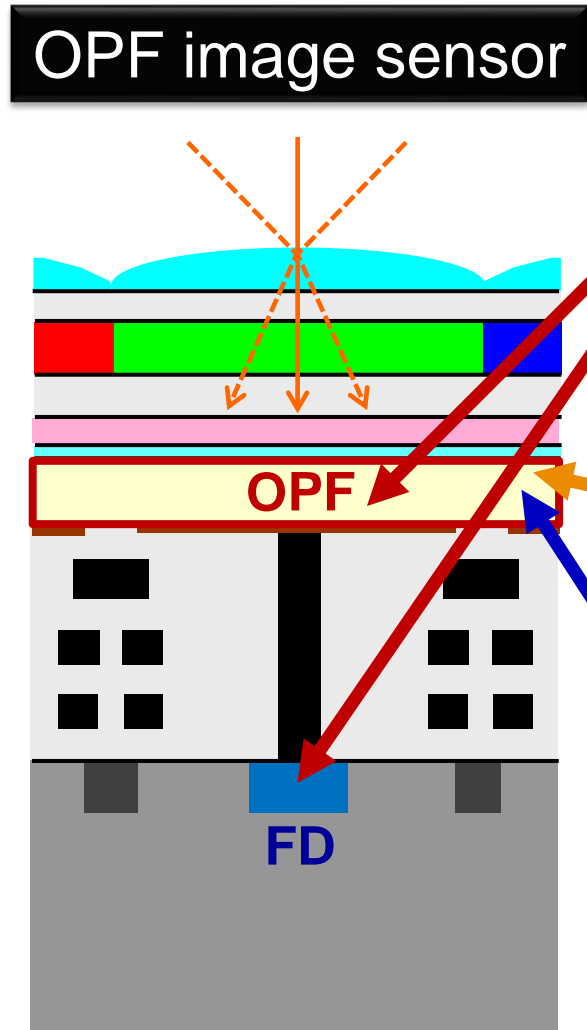
Key Tech. 1: Wide dynamic range

Photoelectric conversion and charge storage parts are completely independent

Key Tech. 2: Global shutter

Photoelectric conversion can be controlled

Advanced Technologies of OPF Image Sensor



Key Tech. 1: Wide dynamic range

Photoelectric conversion and charge storage parts are completely independent

Key Tech. 2: Global shutter

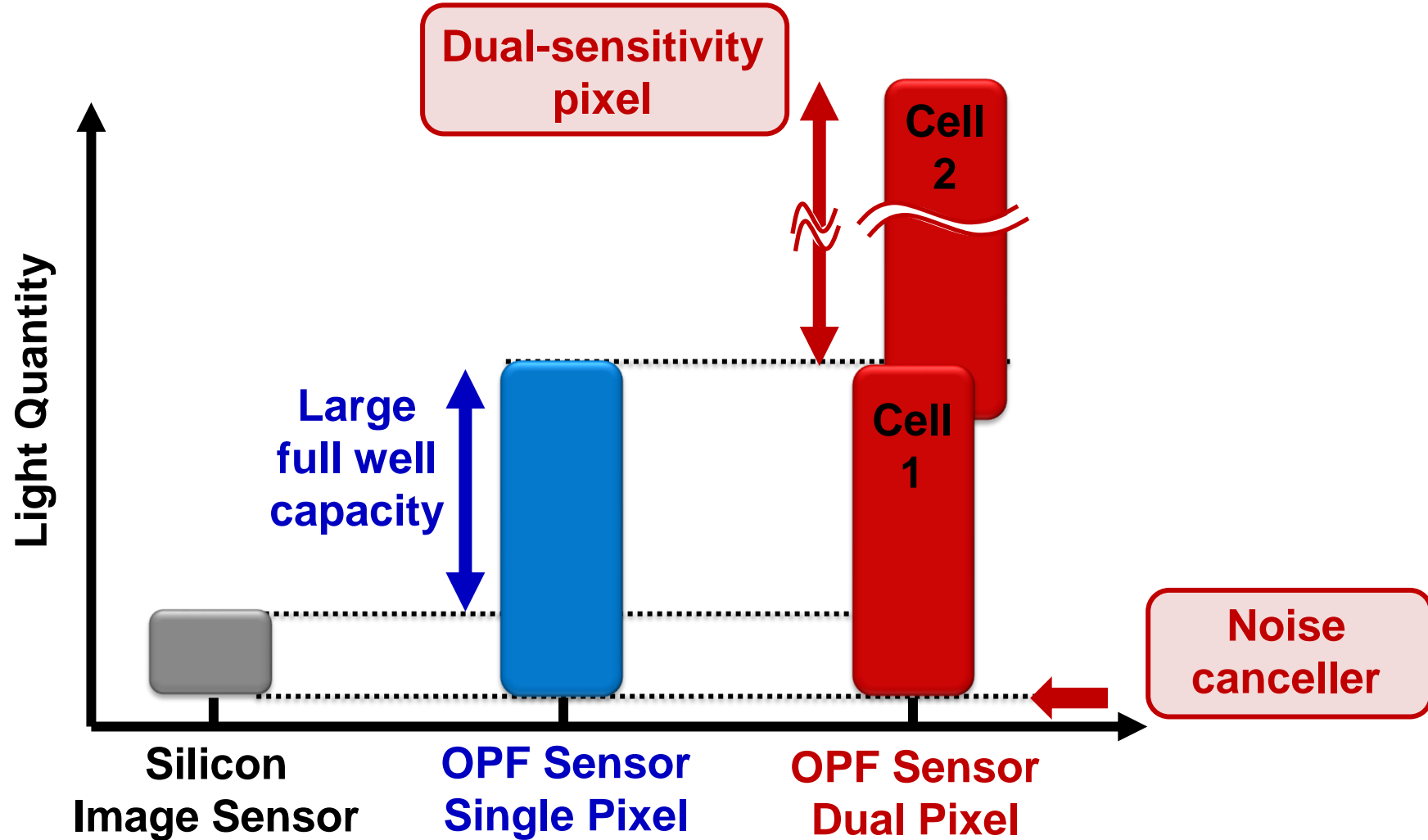
Photoelectric conversion can be controlled

Key Tech. 3: RGB-NIR sensing

NIR sensitivity is very high, and NIR sensitivity can be modulated

Key Tech. 1

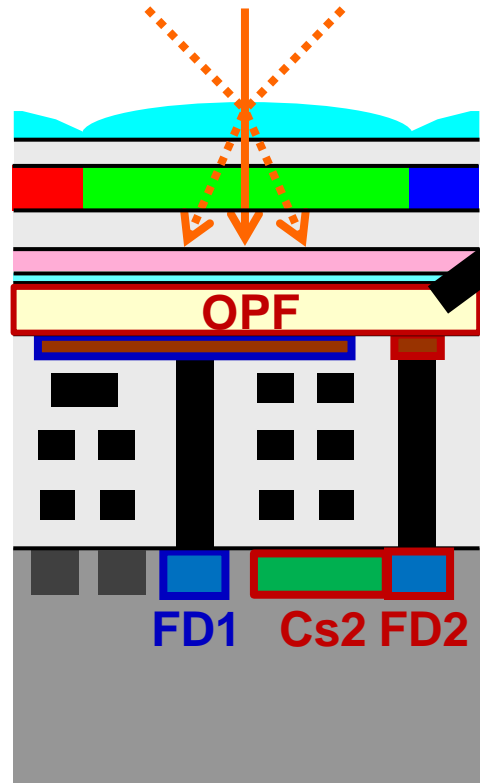
Wide Dynamic Range Technology



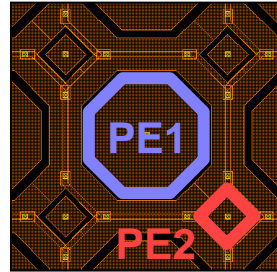
Key Tech. 1

Wide Dynamic Range Technology

Dual Sensitivity-Pixel



Pixel Electrode



$$\begin{aligned} \text{PE1:PE2} &= 1:\frac{1}{10} \\ C_{\text{FD1}}:C_{\text{FD2}}+C_{\text{S2}} &= 1:10 \end{aligned}$$

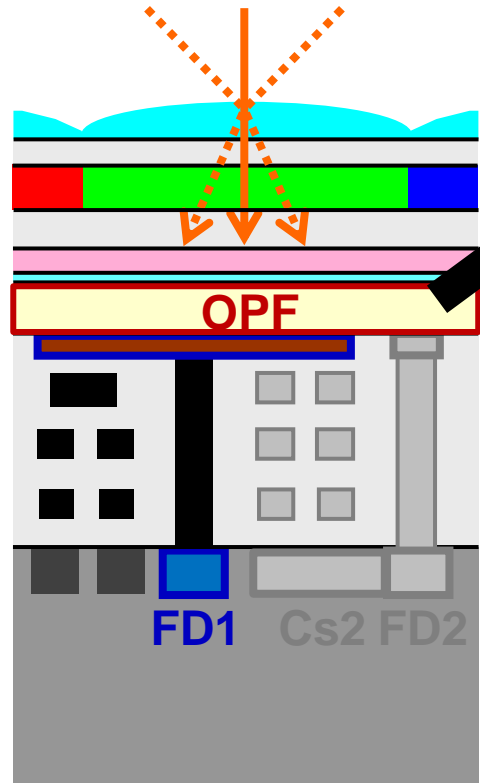
Cell1:
High Sensitivity

Cell2:
High Saturation

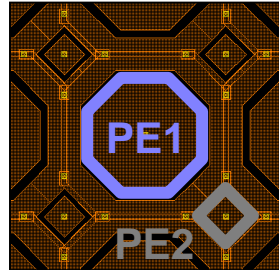
Key Tech. 1

Wide Dynamic Range Technology

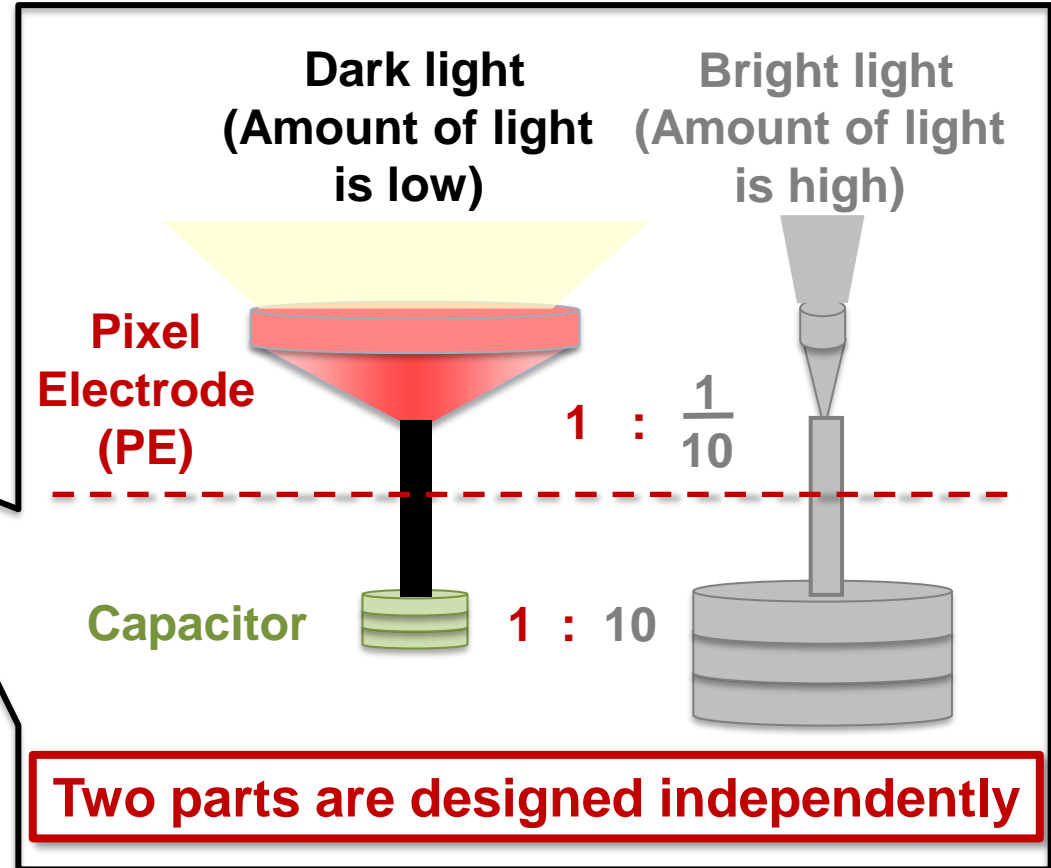
Dual Sensitivity-Pixel



Pixel Electrode



$$\begin{aligned} \text{PE1:PE2} &= 1 : \frac{1}{10} \\ C_{\text{FD1}} &= C_{\text{FD2}} + C_{\text{S2}} \\ &= 1 : 10 \end{aligned}$$



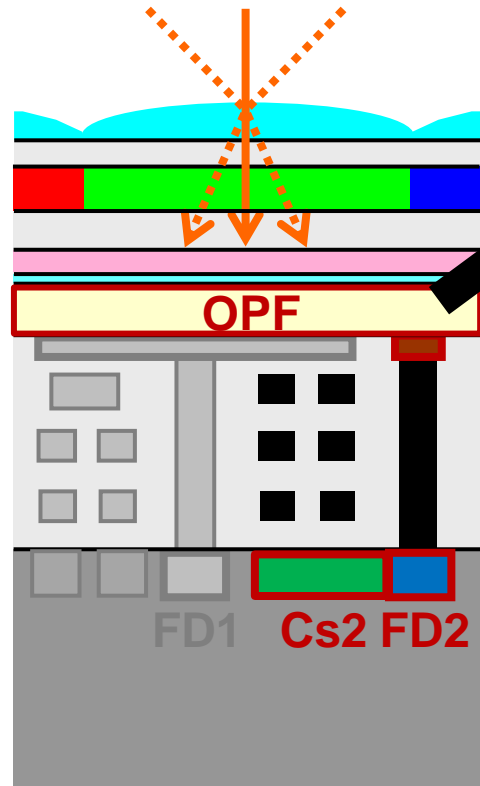
Cell1:
High Sensitivity

Cell2:
High Saturation

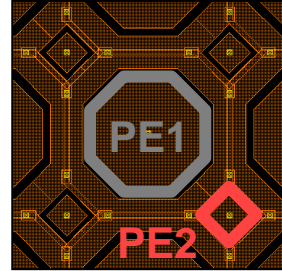
Key Tech. 1

Wide Dynamic Range Technology

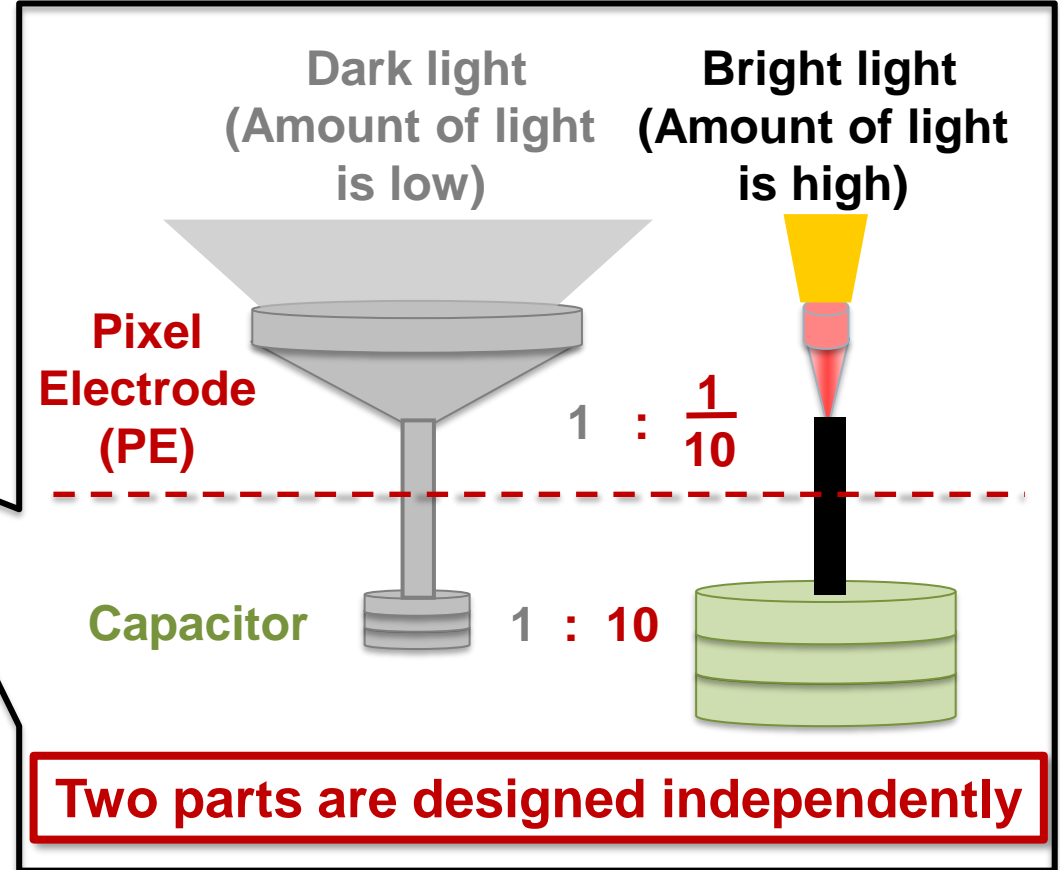
Dual Sensitivity-Pixel



Pixel Electrode



$$\begin{aligned} \text{PE1:PE2} &= 1 : \frac{1}{10} \\ C_{\text{FD1}} : C_{\text{FD2}} + C_{\text{S2}} &= 1 : 10 \end{aligned}$$



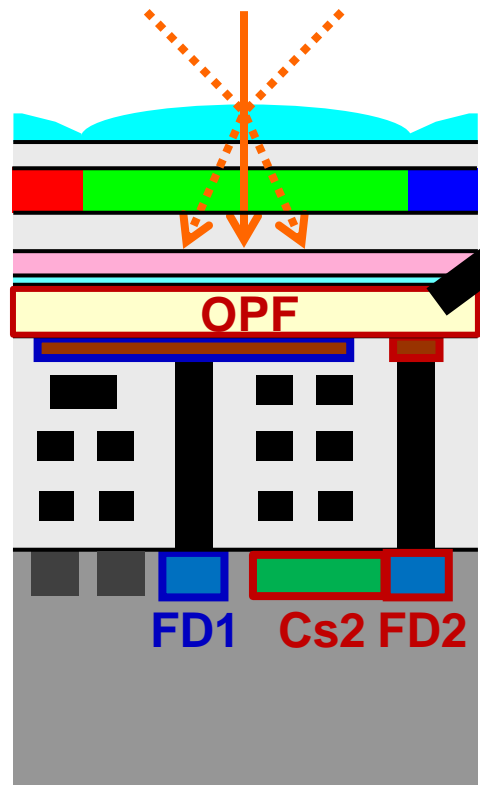
Cell1:
High Sensitivity

Cell2:
High Saturation

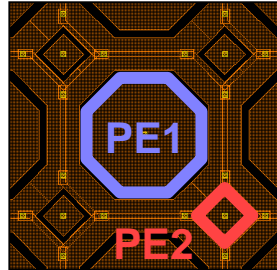
Key Tech. 1

Wide Dynamic Range Technology

Dual Sensitivity-Pixel



Pixel Electrode

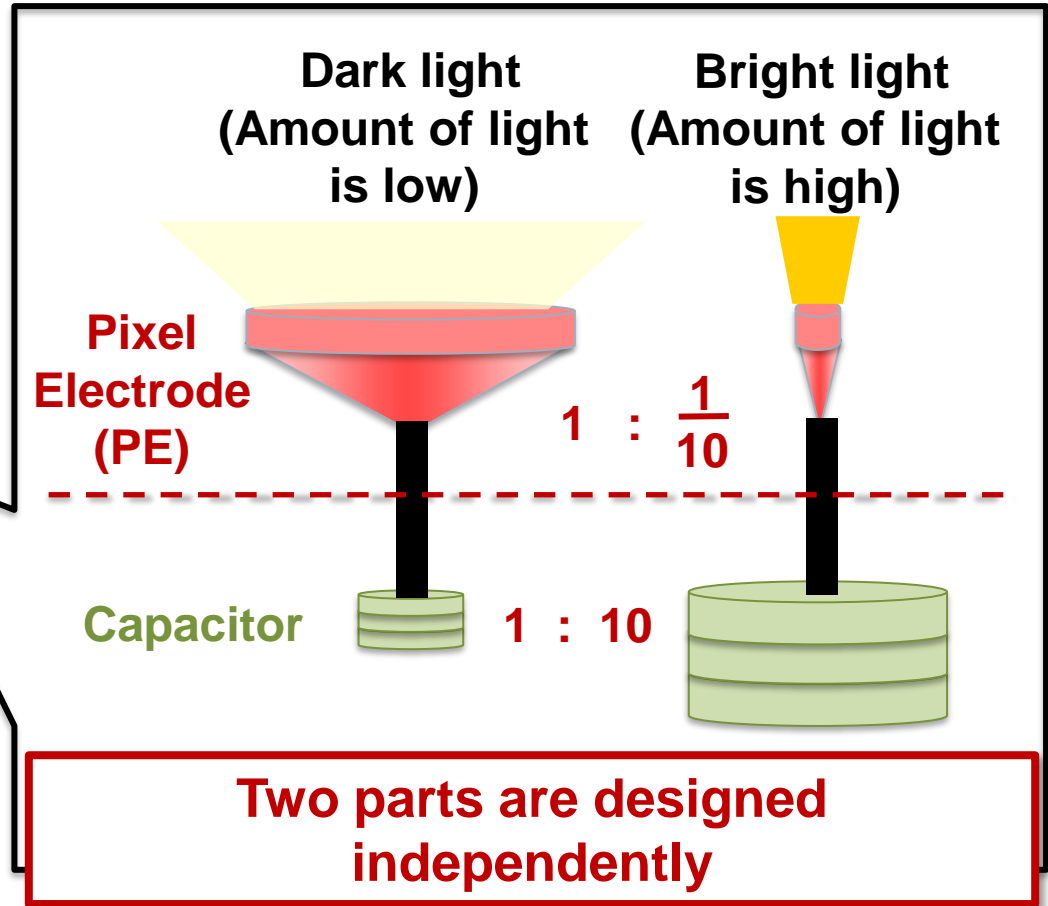


$$\begin{aligned} \text{PE1:PE2} &= 1 : \frac{1}{10} \\ C_{\text{FD1}} : C_{\text{FD2}} + C_{\text{S2}} &= 1 : 10 \end{aligned}$$

**100 times
SC-WDR**

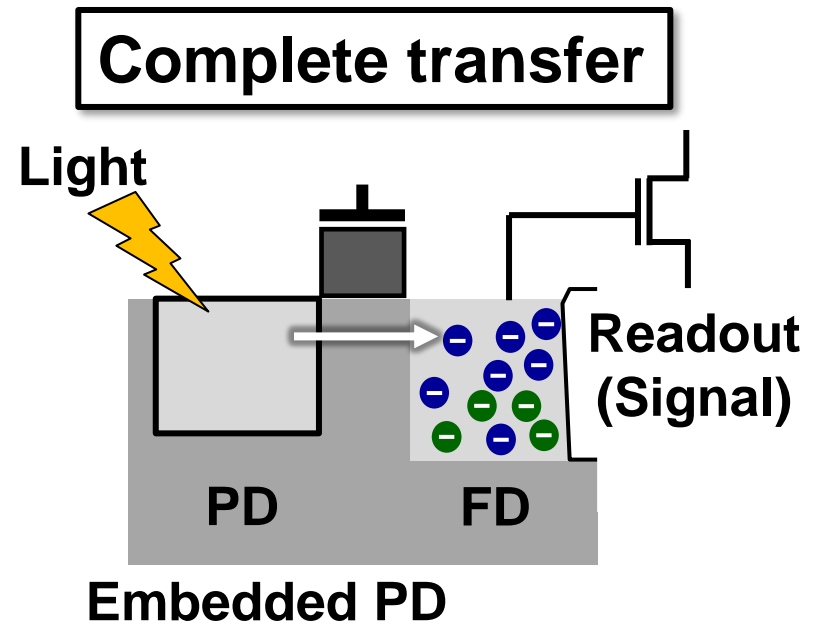
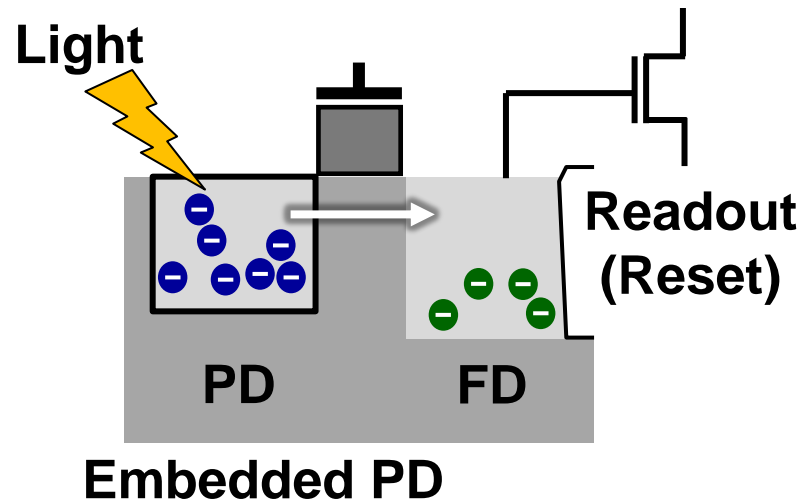
**Cell1:
High Sensitivity**

**Cell2:
High Saturation**



Reset Noise in Dark Region

Silicon Image Sensor

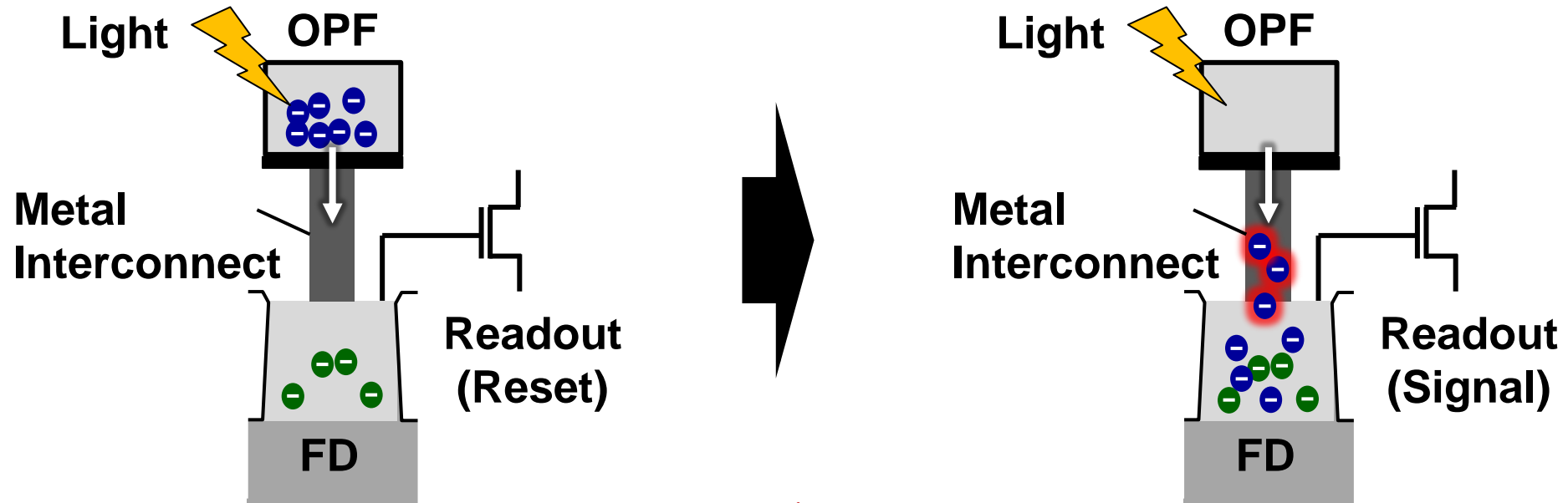


CDS method can be used
Reset noise is not a problem

CDS: Correlated Double Sampling

Reset Noise in Dark Region

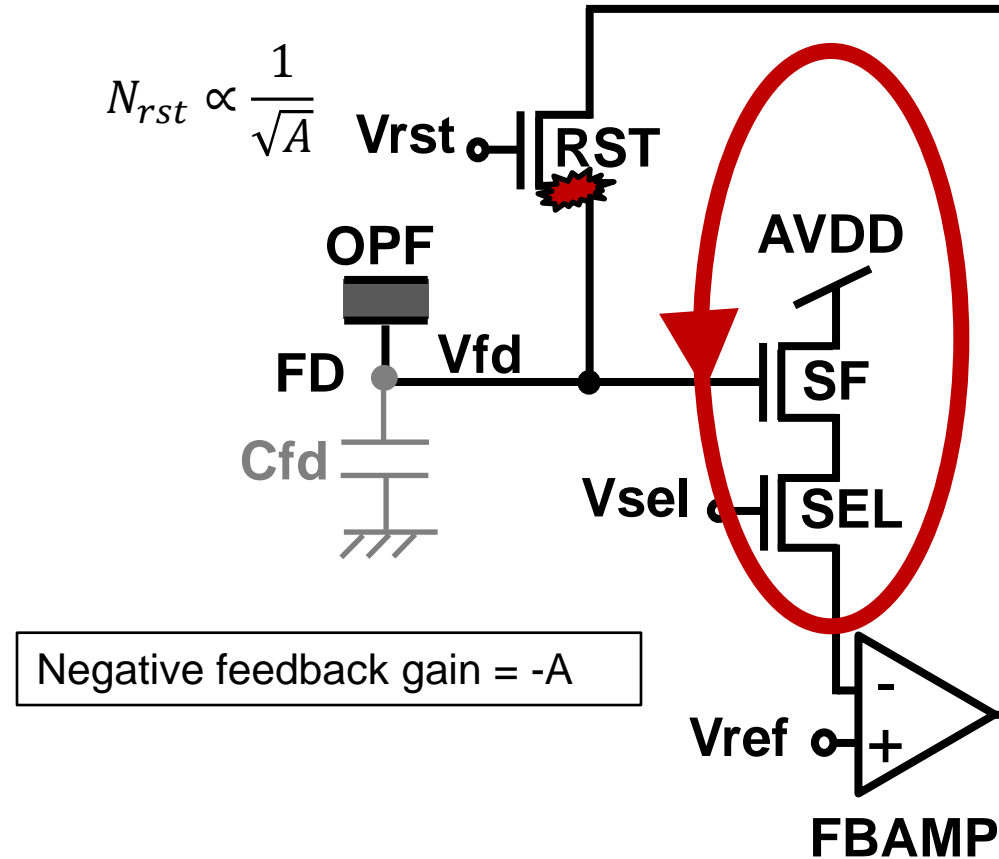
OPF Image Sensor



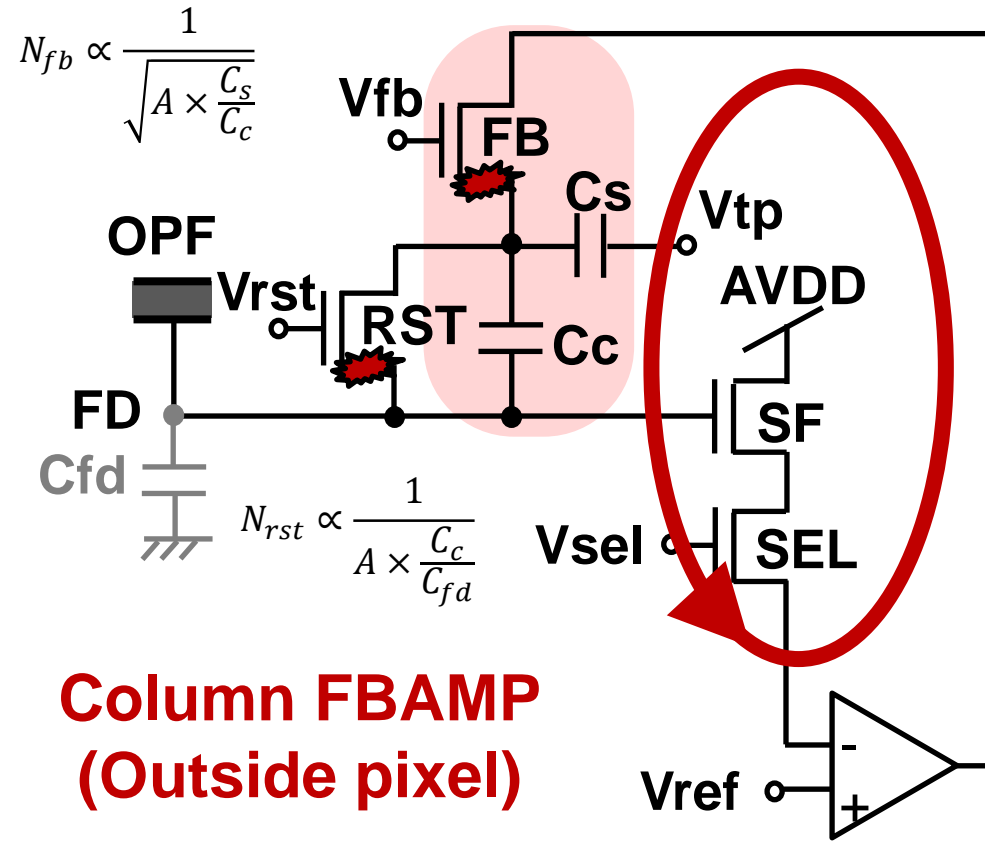
Problem

**Reset noise is left on the FD
(include the Metal Interconnect)**

M.Ishii VLSI2013



K.Nishimura ISSCC2016

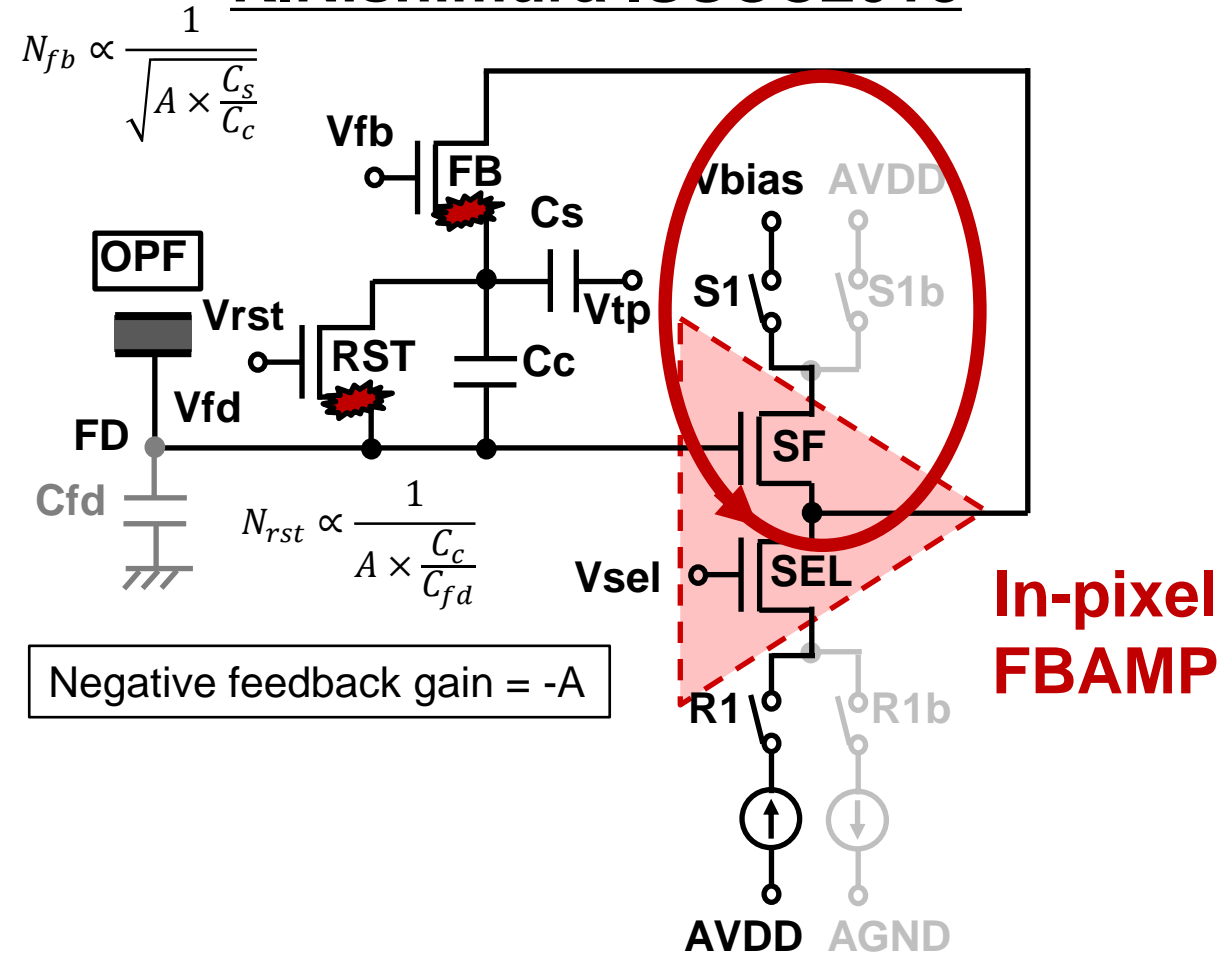


**Column FBAMP
(Outside pixel)**

Negative feedback gain = -A

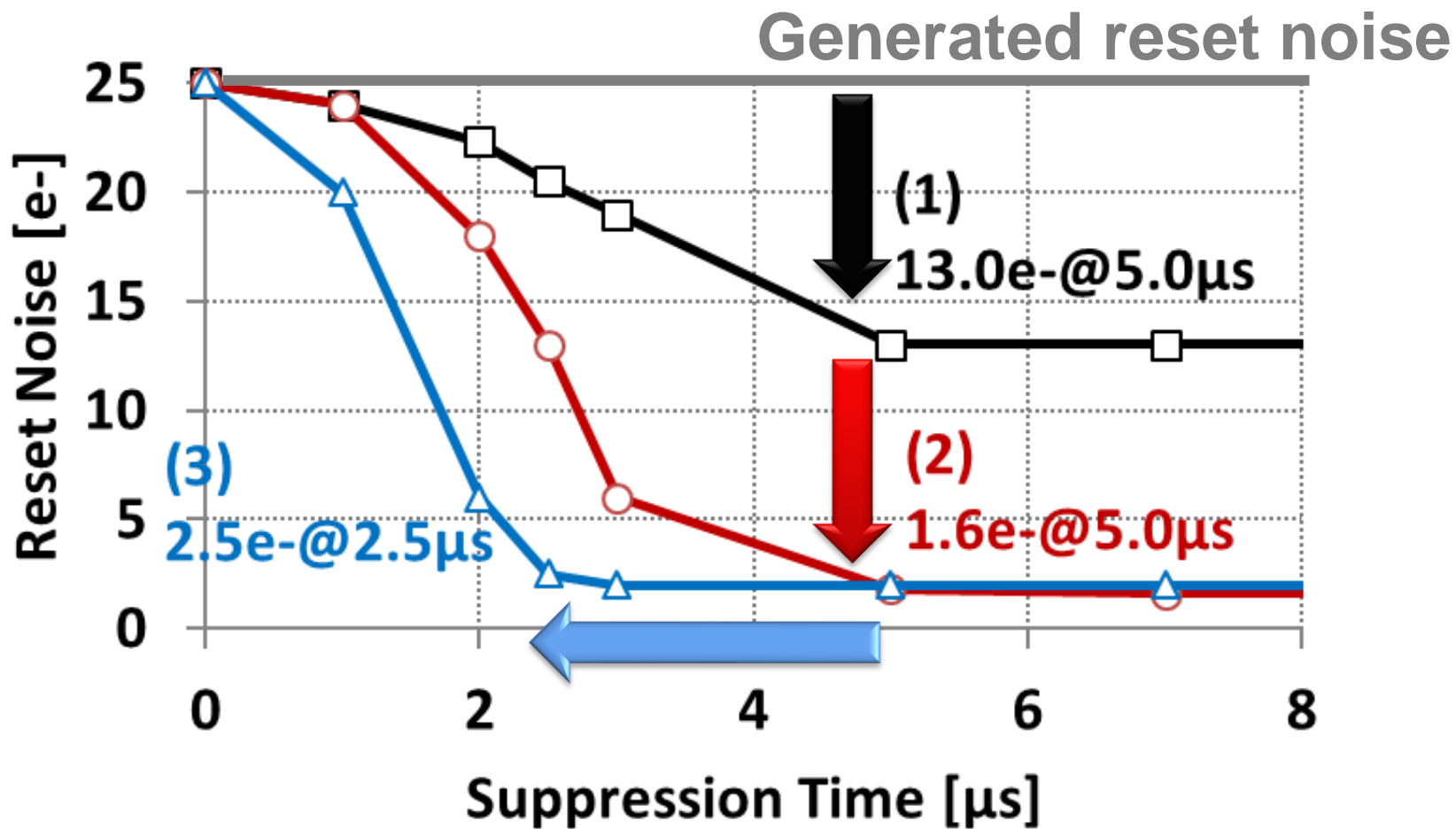
*FBAMP: Feedback Amplifier

K.Nishimura ISSCC2018



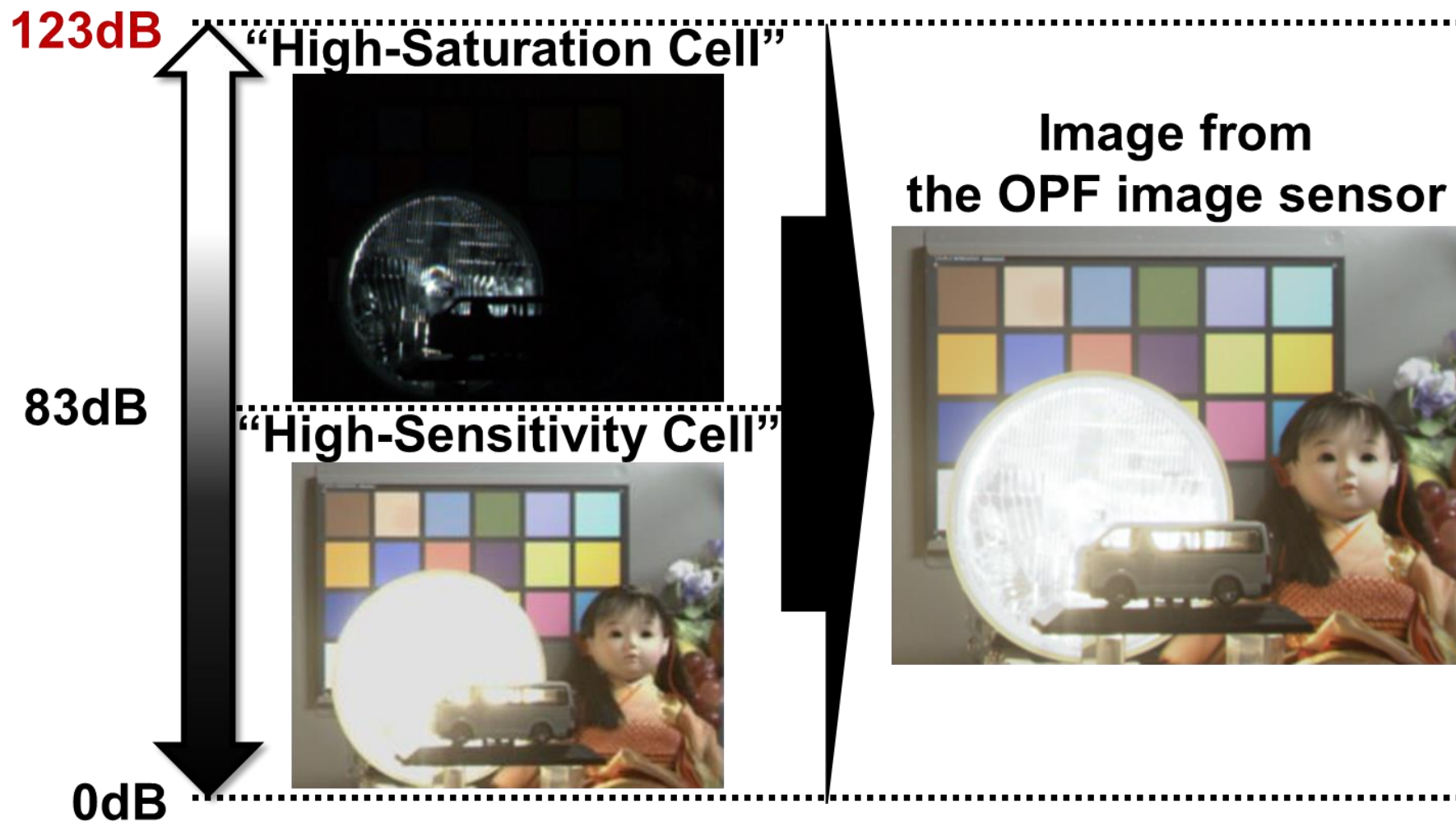
Key Tech. 1

Comparison of Noise Cancellation Methods

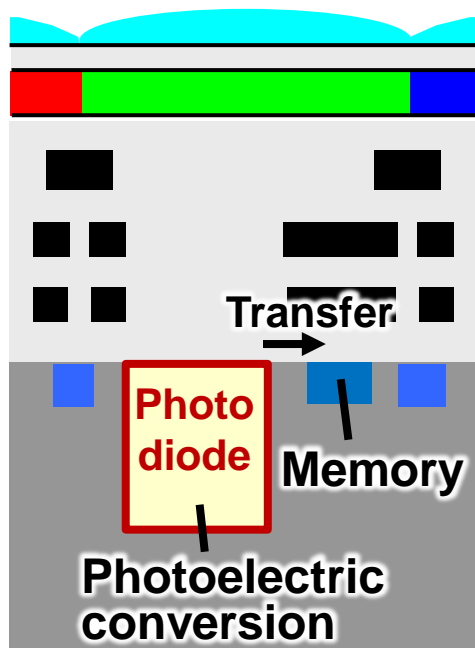


Key Tech. 1

Captured Image: Wide Dynamic Range

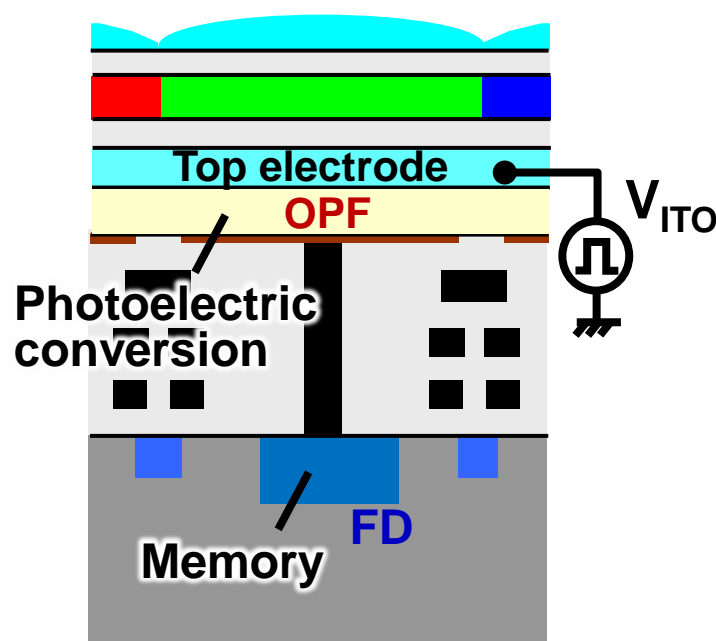


Conventional GS Sensor



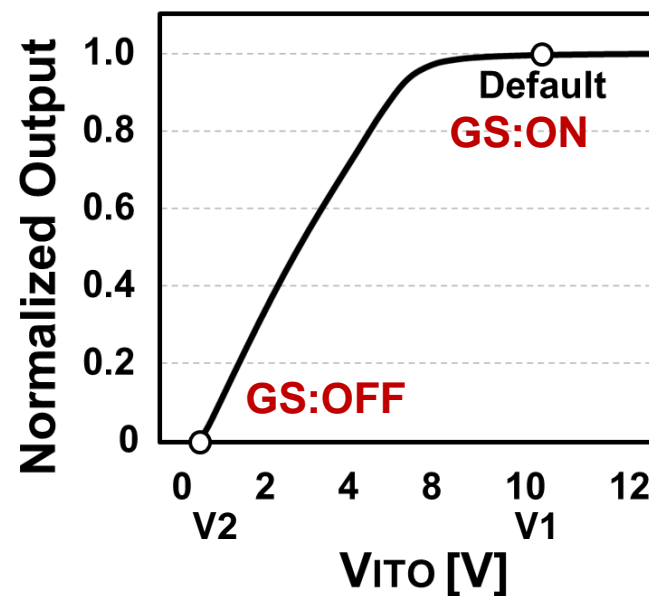
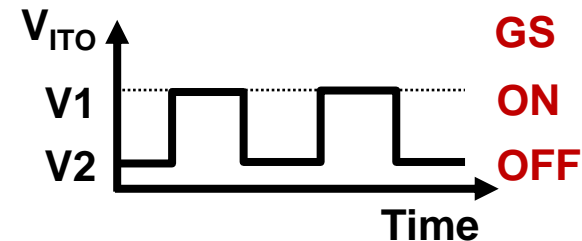
Add storage node and transistors

OPF GS Sensor



Apply pulsed voltage to top electrode

S. Shishido ISSCC2016

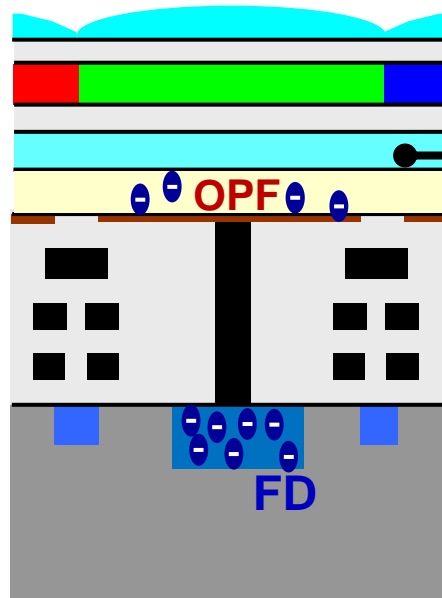


Key Tech. 2

Operation of OPF Global Shutter

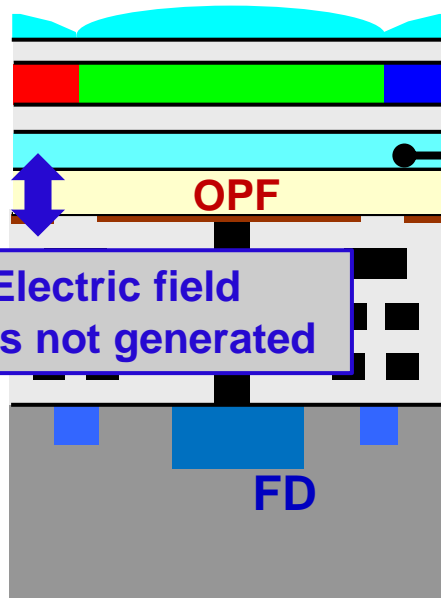
OPF GS Sensor

Exposure time



$V_{ITO} = \text{High}$

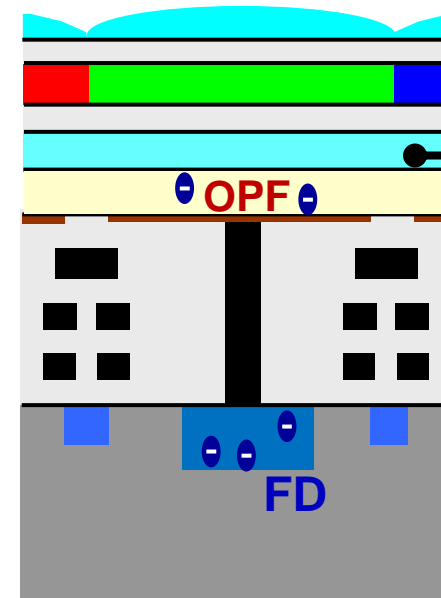
Light shield and readout time



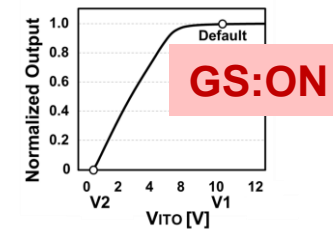
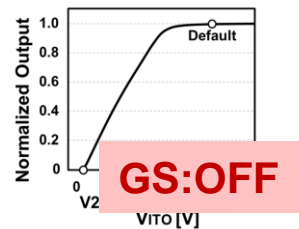
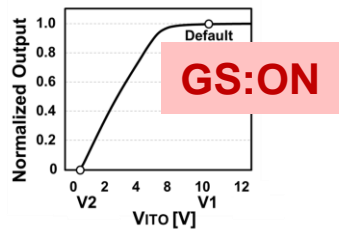
$V_{ITO} = \text{Low}$

Electric field is not generated

Next exposure time

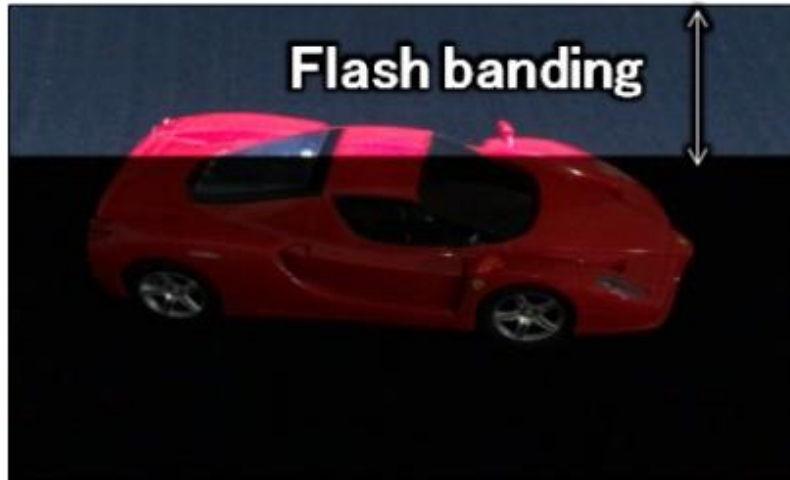


$V_{ITO} = \text{High}$



Captured Image: Global Shutter

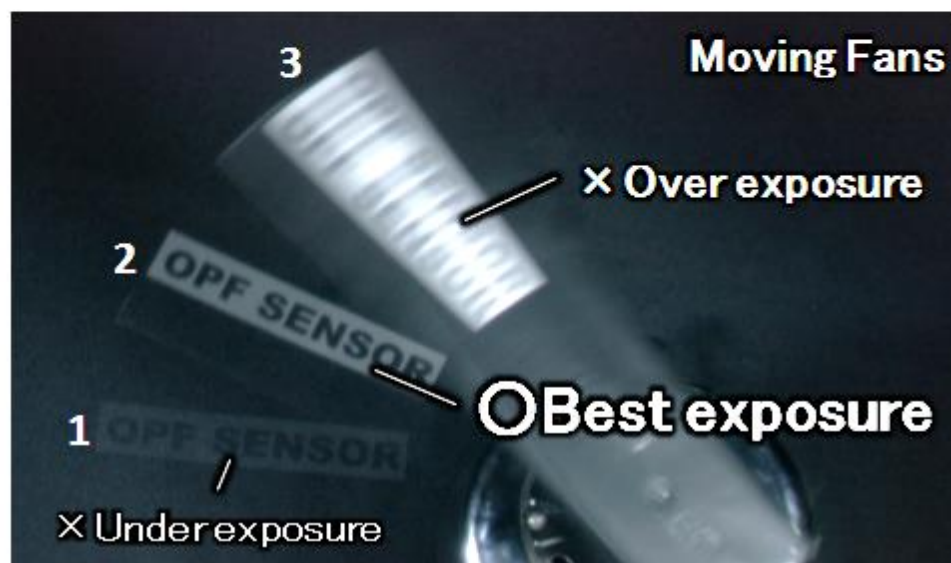
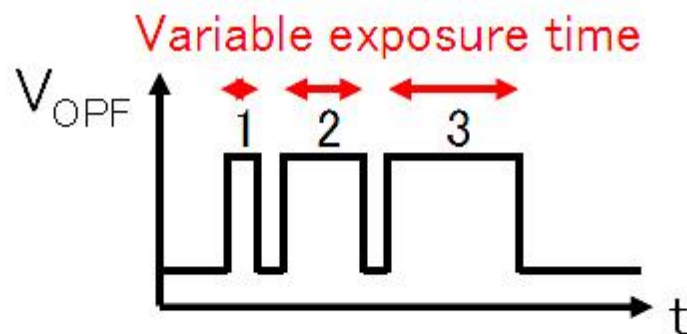
Rolling Shutter Mode



Global Shutter Mode



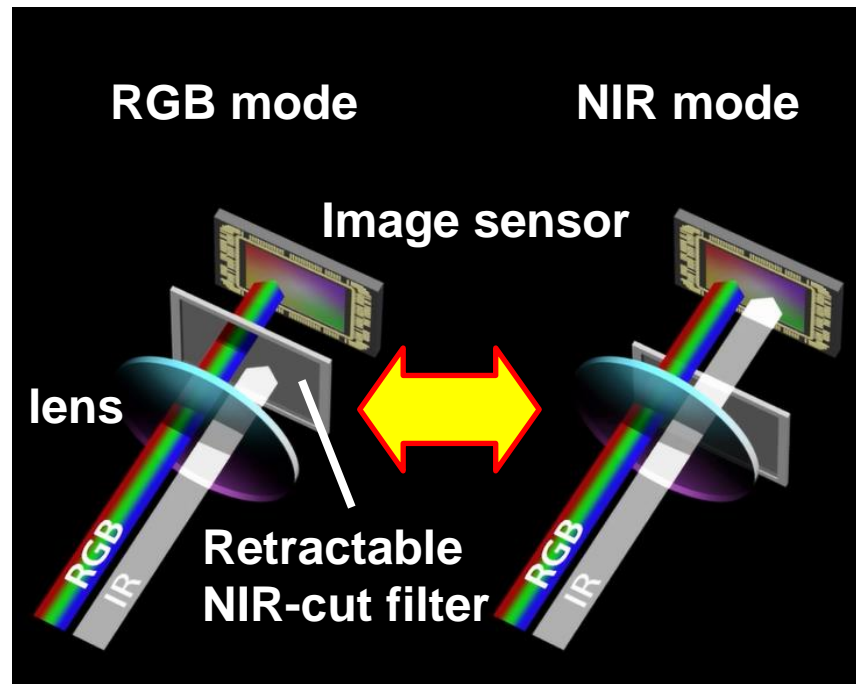
Multiple Exposure by Variable Pulse Duty



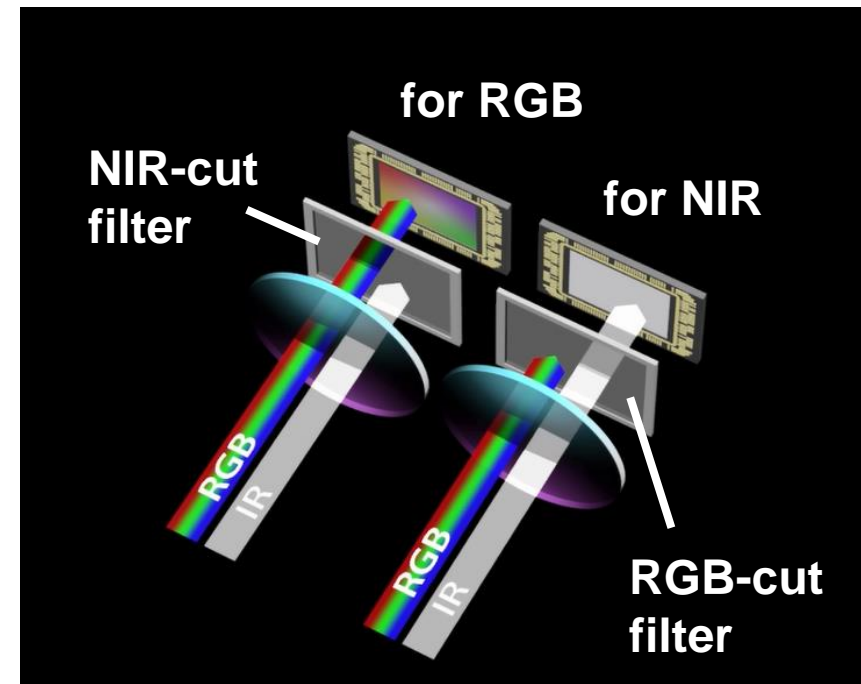
Key Tech. 3 RGB-NIR Sensor Conventional Issue

- RGB capturing **needs to prevent NIR** from entering an image sensor

Method1: Retractable NIR-cut filter
Issue: increased components

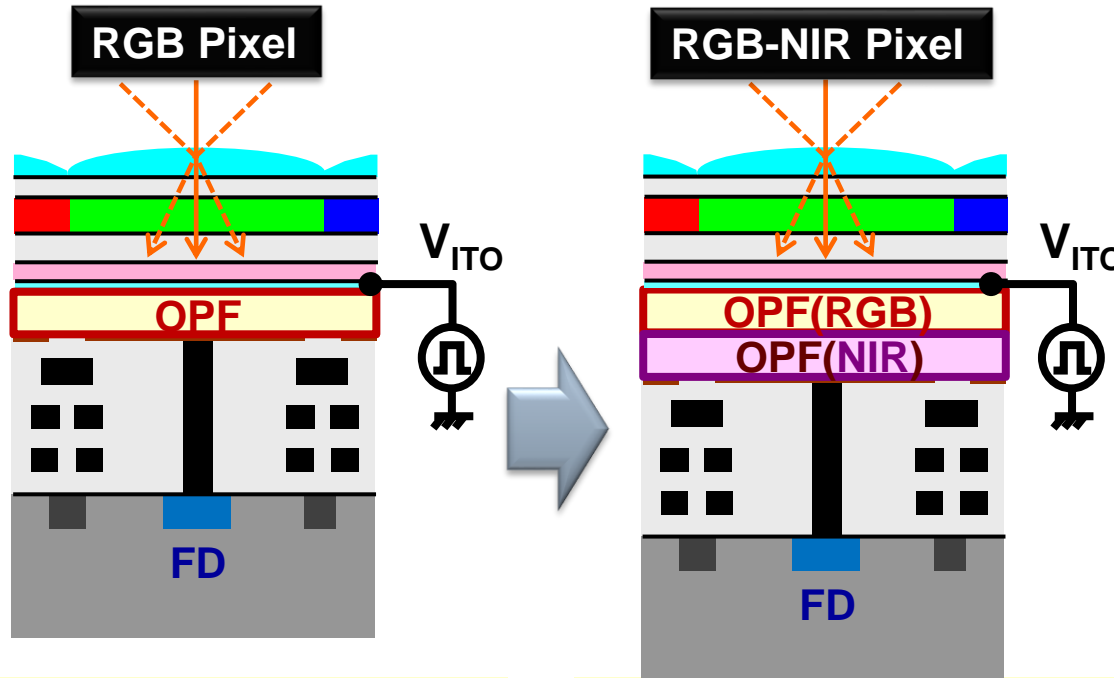


Method2: Two sensors
Issue: parallax error

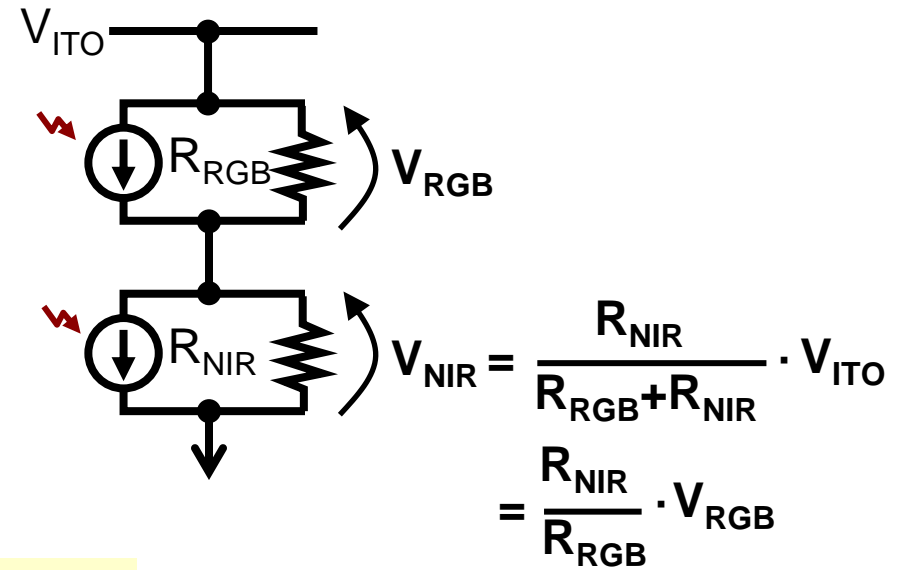


Key Tech. 3 Electrical control of NIR sensitivity

- Voltages applied to each OPF can be **controlled with the same voltage source depending on the resistance ratio**



S. Machida ISSCC2017

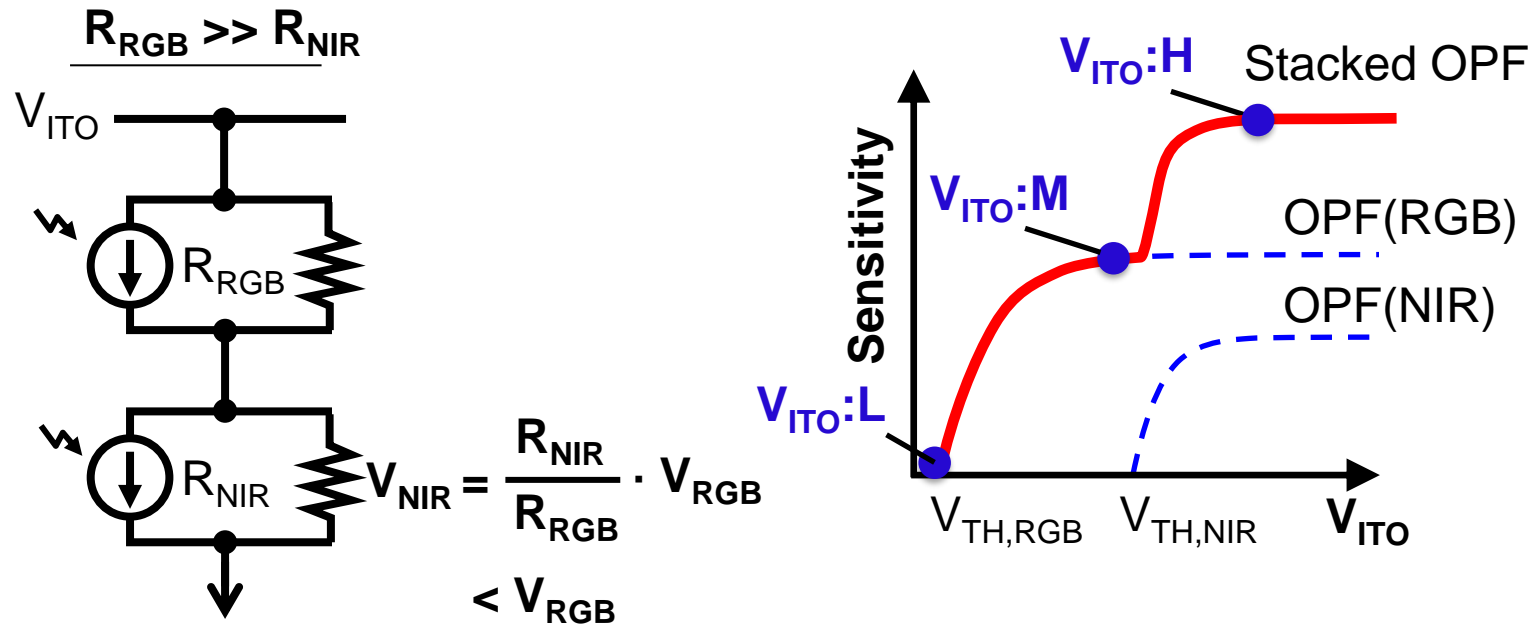


$V_{ITO} = \text{High}$: ON mode
 $V_{ITO} = \text{Low}$: OFF mode

$V_{ITO} = \text{High}$: RGB-NIR mode
 $V_{ITO} = \text{Mid}$: RGB mode
 $V_{ITO} = \text{Low}$: OFF mode

Key Tech. 3 Electrical control of NIR sensitivity

- **NIR sensitivity is controllable** while maintaining the RGB-OPF in the ON-state



$V_{ITO} = \text{High}$: RGB-NIR mode ($V_{ITO} > V_{TH,NIR} > V_{TH,RGB}$)

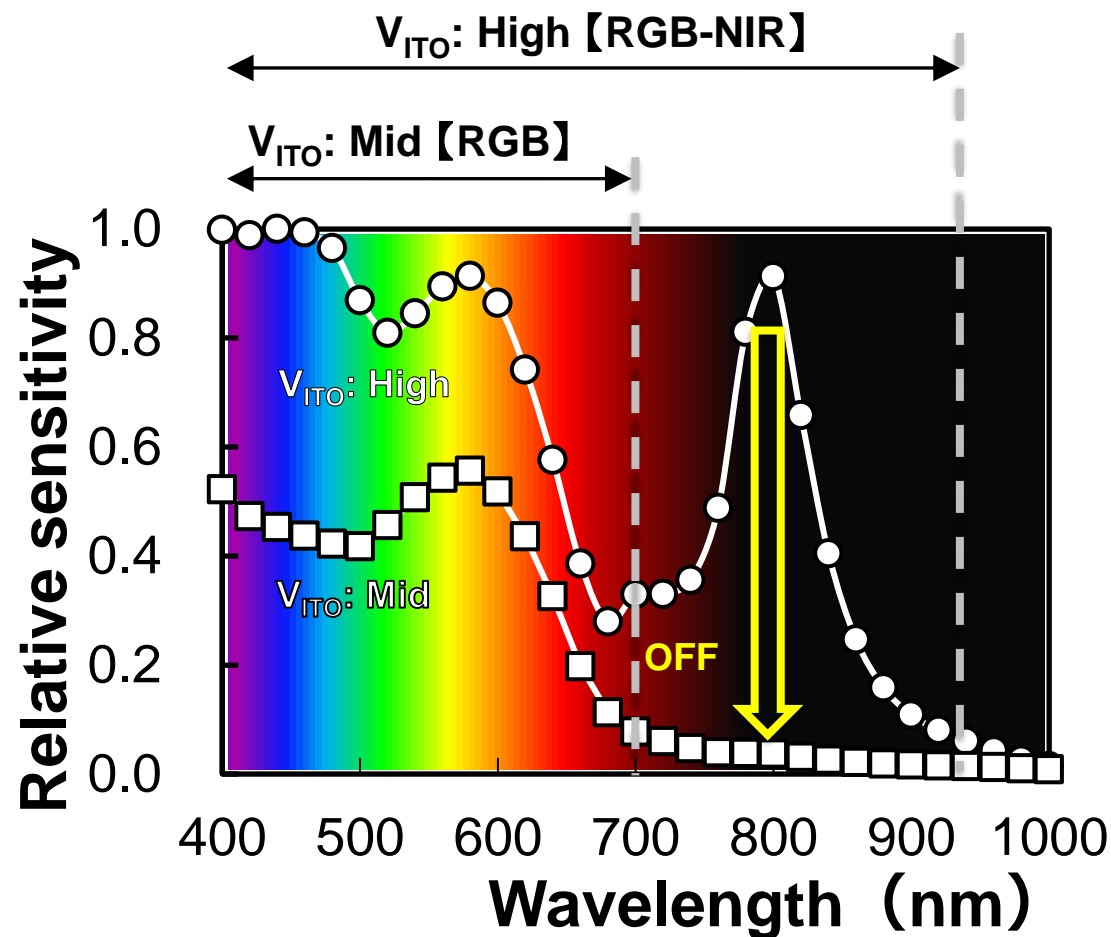
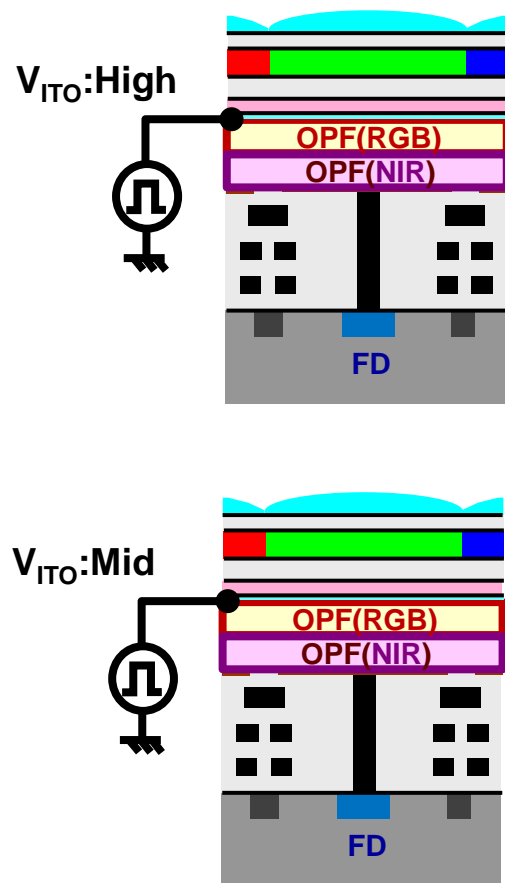
$V_{ITO} = \text{Mid}$: RGB mode ($V_{TH,NIR} > V_{ITO} > V_{TH,RGB}$)

$V_{ITO} = \text{Low}$: OFF mode ($V_{TH,NIR} > V_{TH,RGB} > V_{ITO}$)

Key Tech. 3

Electrical control of NIR sensitivity

- Controlling NIR sensitivity without NIR-cut filter is realized



Key Tech. 3 Captured Image: RGB-NIR sensor

- **Non-destructive inspection** can be realized

RGB Mode

RGB-NIR Mode



The tank containing soy sauce that is transparent only with NIR sensitivity.

Key Tech. 3 Captured Image: RGB-NIR sensor

- **Non-destructive inspection** can be realized
- RGB and RGB-NIR modes can be changed **frame by frame**

RGB Mode



RGB-NIR Mode



The barcode is painted with special ink that is transparent only with NIR sensitivity.

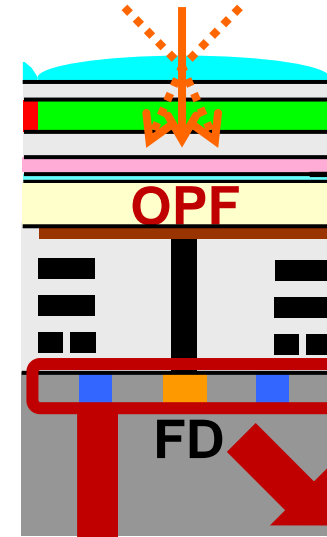
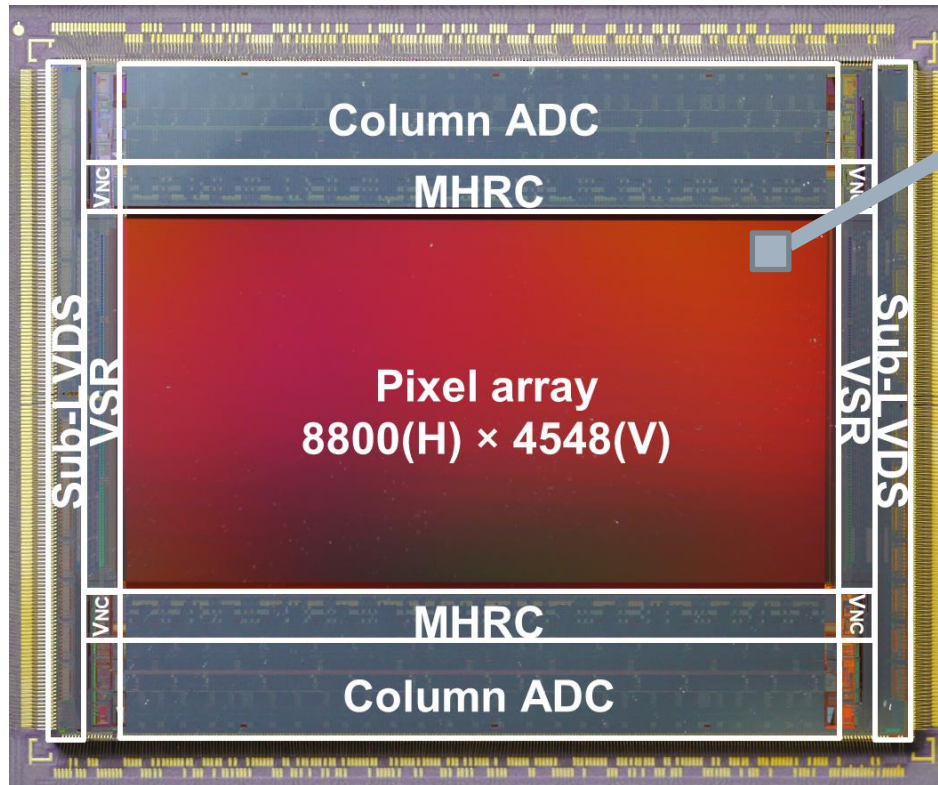
Outline

- Background
 - What is OPF image sensor
 - Advanced technologies of OPF image sensor
 - 1) Wide dynamic range
 - 2) Photoelectric conversion controlled global shutter
 - 3) NIR sensitivity modulation RGB-NIR sensor
 - **8K4K sensor technologies**
 - Conclusion
-

8K4K High-Resolution Image Sensor

8K4K OPF image sensor

65nm CMOS process, Pixel size: $3\mu\text{m} \times 3\mu\text{m}$



Sensitivity modulation
⇒ Global shutter

Single type OPF pixel
⇒ High-saturation

In-pixel reconfigurable structure
⇒ High-speed noise cancel
⇒ High-speed readout

Captured Image: 8K Resolution

8K



Captured Image: 8K Resolution

8K



Captured Image: 8K Resolution



Captured Image: 8K Resolution



Captured Image: 8K Resolution



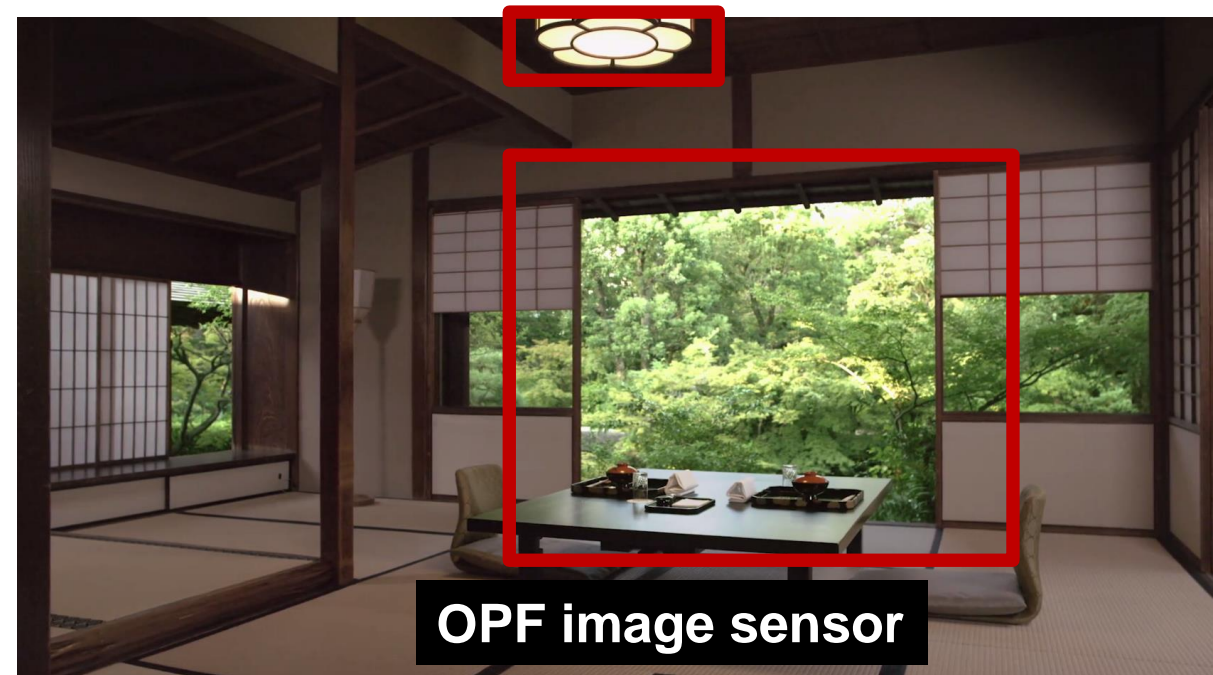
Captured Image: Wide Dynamic Range

➤ **8K resolution** and **wide dynamic range** image can be captured.



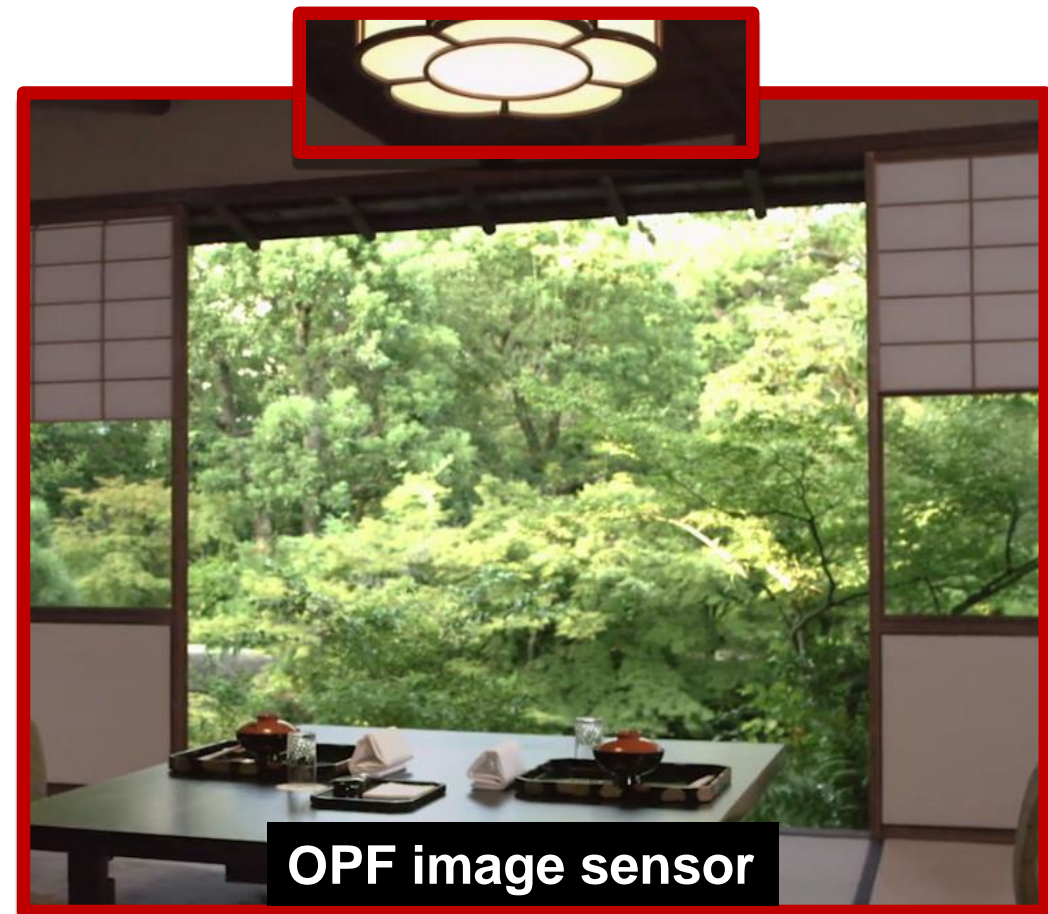
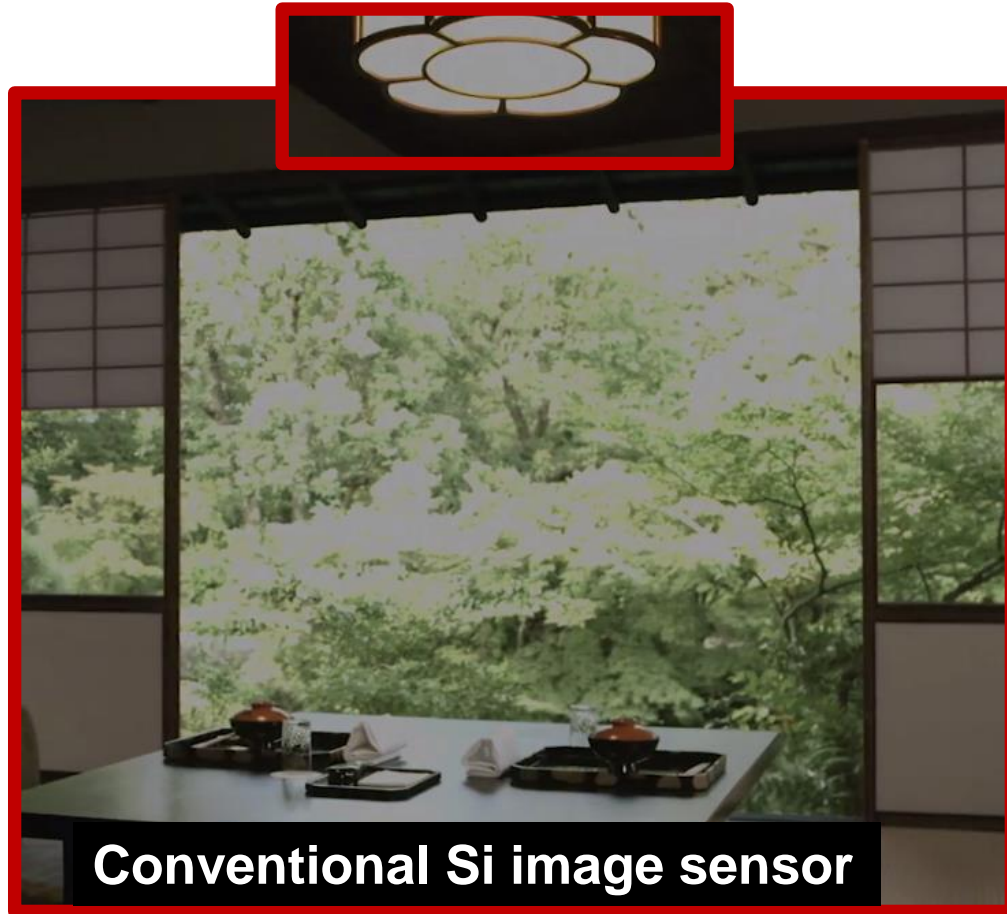
Captured Image: Wide Dynamic Range

➤ **8K resolution** and **wide dynamic range** image can be captured.



Captured Image: Wide Dynamic Range

➤ **8K resolution** and **wide dynamic range** image can be captured.



Captured Image: Global Shutter

- By using **global shutter function**, **shutter distortion does not occur** even during high-speed panning image capturing.

Rolling shutter mode



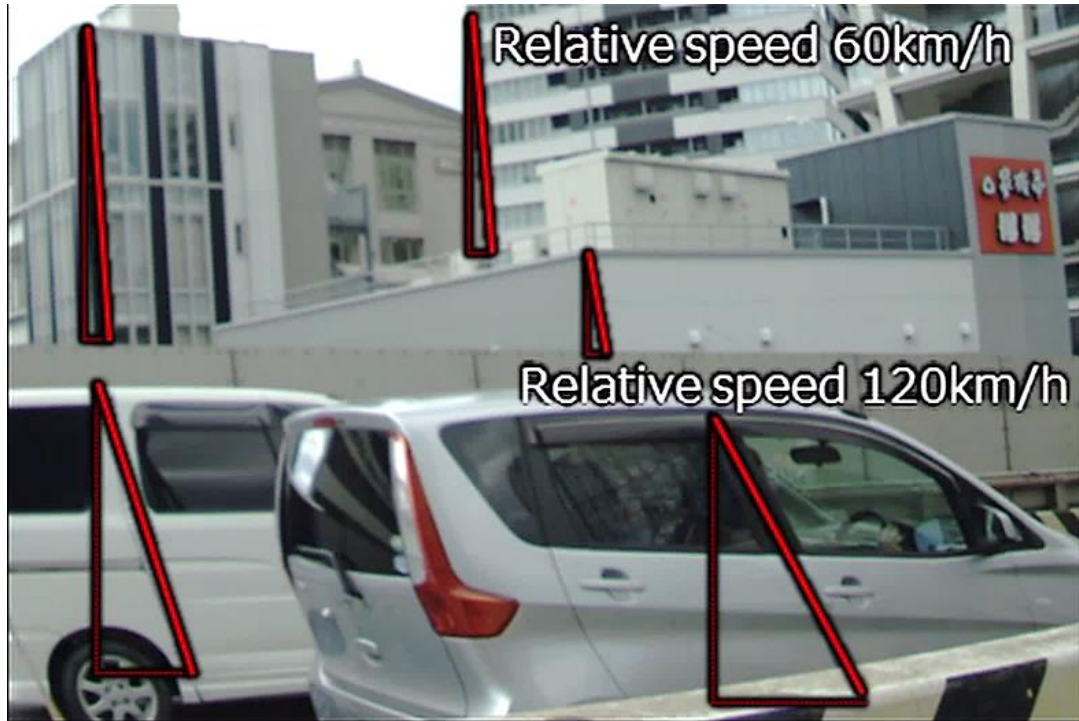
Global shutter mode



Captured Image: Global Shutter

- By using **global shutter function**, **shutter distortion does not occur** even during high-speed moving image capturing.

Rolling shutter mode



Global shutter mode



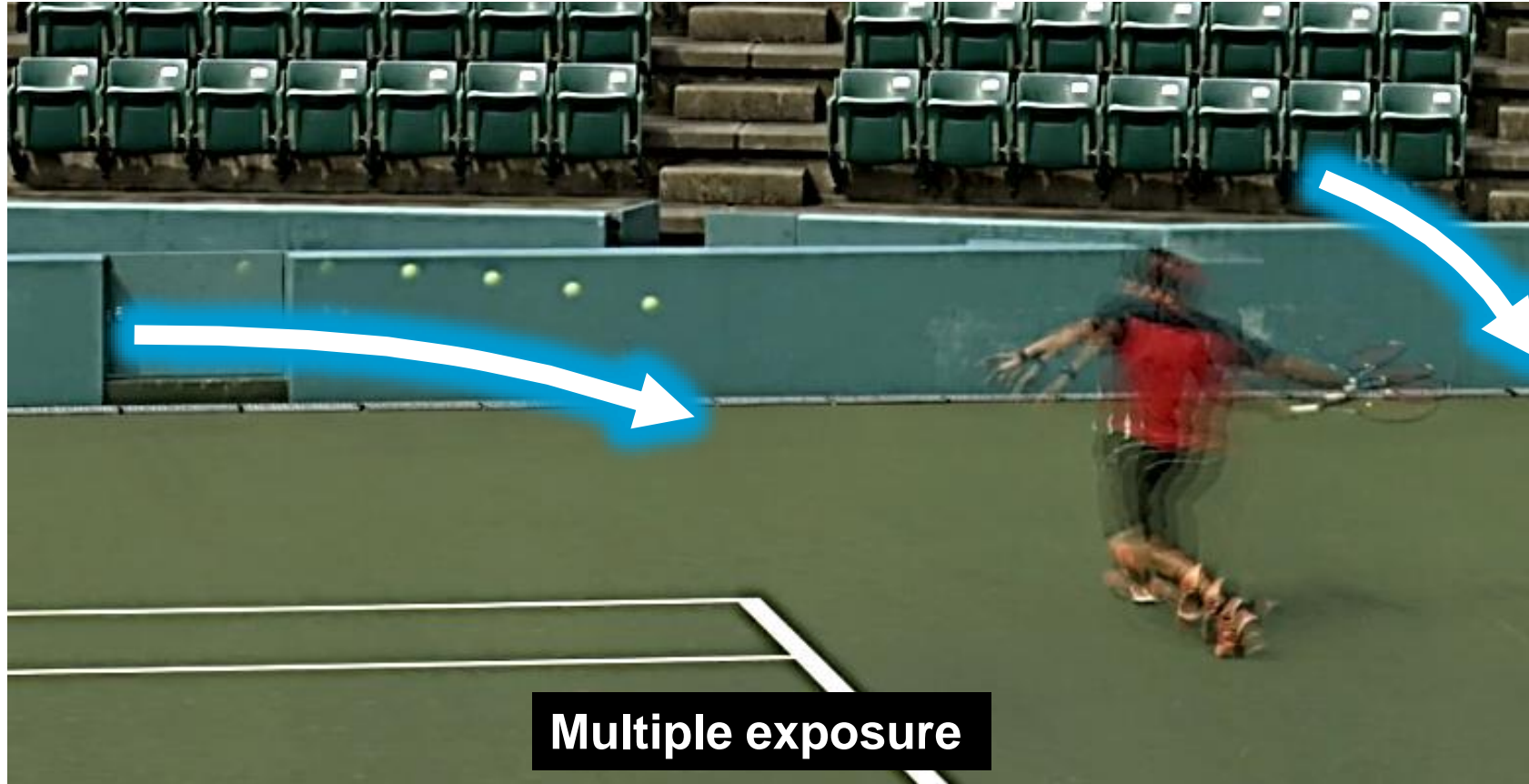
Captured Image: Global Shutter's Multiple Exposure

- By using **global shutter function**, the desired moment can be captured without shutter distortion.



Captured Image: Global Shutter's Multiple Exposure

- By using **multiple exposure of global shutter function**, **motion detection** can be realized.



Outline

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-

Conclusion

In the near future, the demands for image sensors will shift

- Capturing precise images



- Recognizing captured data
- Seeing something invisible
- Predicting the next action

We will contribute to these “smart edge” demands through advanced OPF image sensor technologies.

Thank you for your attention !

Panasonic